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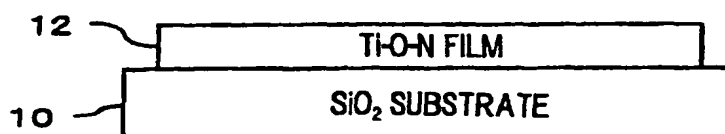
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(54) **PHOTOCATALYTIC MATERIAL, PHOTOCATALYTIC ARTICLE AND METHOD FOR THEIR
PREPARATION**

(57) In titanium oxide crystals, nitrogen atoms are substituted for some of the oxygen sites, doped at interstitial sites of crystal lattices, or doped in grain boundaries, or a combination of these methods is employed. As a result, a chemical bond between Ti and N atoms is

present in the crystals and a photocatalytic activity is exhibited by absorbing visible light. For example, Ti-O-N film with a film thickness 10µm or less is formed on a substrate. Thus, a photocatalytic material may be obtained which exhibits a photocatalytic activity with visible light.

Fig. 1



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Description

TECHNICAL FIELD

[0001] The present invention relates to a photocatalytic material which is capable of exhibiting photocatalytic activity when irradiated with visible light as well as ultraviolet light, a photocatalytic substance, and a method for their preparation.

BACKGROUND ART

[0002] Hitherto, known materials exhibiting a photocatalytic action include the likes of TiO_2 (titanium dioxide), CdS (cadmium sulfide), WO_3 (tungsten trioxide), and ZnO (zinc oxide). These photocatalytic materials are semiconductors, absorb light to form electrons and holes, and present various chemical reactions and bactericidal actions. However, because titanium oxide is nontoxic and is superior from the standpoint of stability to water and acid, so far only titanium oxide has been put to practical commercial use as a photocatalyst.

[0003] However, because of the values of the band gap ($E_g = 3.2\text{eV}$) of titanium oxide, the operating light of such a titanium oxide photocatalyst is limited to ultraviolet light with a wavelength $\lambda < 380\text{nm}$. As a consequence, there remains an unfulfilled demand for development of materials which exhibit catalytic activity when irradiated with visible light with a wavelength of 380nm or longer. These materials are desired, for example, for use indoors and for improving photocatalytic activity.

[0004] As described in Japanese Patent Laid-Open publication No. Hei 9-262482, by modifying materials using ion implanting of metal elements such as Cr (chrome) and V (vanadium) in anatase type titanium oxide having a high catalytic activity, the light absorbing edge of titanium oxide can be shifted to the long wavelength side to permit the operation of titanium oxide catalyst in visible light. Although a number of reports discussing the doping of Cr, V, and so on have been published since the early 1970s, these reports describe that in this instances where operation under visible light is enabled, the performance of titanium oxide sharply lowers.

[0005] On the other hand, as described in Japanese Patent Laid-Open publication No. Hei 9-262482, the original performance of titanium oxide can be maintained through use of special techniques for doping Cr, V, and so on.

[0006] Thus, in the above conventional example, the operation of titanium oxide photocatalyst under visible light is made possible by a technique of ion implanting metal elements in titanium oxide. However, metal ion implantation is disadvantageous because of its high cost. While there is a demand for other methods of manufacturing and synthesis of TiO_2 photocatalyst, such as synthesis in solution or sputtering, photocatalysts produced through these methods can not operate under visible light. It is generally considered that this is because Cr of the dopant aggregates or forms oxides such as Cr_2O_3 in a crystallization process. Thus, in the conventional art of the examples, the technique of ion implanting must be adopted in order for metal elements to be used to enable operation of titanium oxide under visible light. This method has problems that an expensive large-scale apparatus is required and that very high manufacturing costs cannot be avoided. While there is also an art which aims to realize visible light operation by doping trivalent elements, there is a problem with this art in that the optimum state of the doping of these elements is not realized.

[0007] Furthermore, Japanese Patent Laid-Open publication No. 2000-140636 opened to the public after the filing of the two applications from which the present application claims priority, discloses a method of forming a photocatalytic substance by doping trivalent elements in titanium oxide and that one of aluminum, boron, and nitrogen is used for the trivalent elements. The example given in that publication shows acetaldehyde may be decomposed more efficiently in a powder body in which titanium oxide and its nitrogen dope body are laminated in many layers, than in a titanium oxide powder, when light is irradiated from a natural light fluorescent lamp. However, the titanium oxide in that example is prepared by doping trivalent elements in which nitrogen is merely doped or unintentionally mixed and the photocatalyst is not constructed so as to maximize photocatalytic activity under visible light. In addition, in the example of that publication wherein a fluorescent lamp is employed, description of the effects of ultraviolet light radiated by a fluorescent lamp is included. An experimental method employing a fluorescent lamp, even one designated as natural light, is not suitable for evaluating activity under visible light because improvement in photocatalytic activity might be attributed to enhanced UV activity owing to structural changes, such as increased surface area or the like. Therefore, it should be considered that the true photocatalytic activity under visible light of the nitrogen doped body of this titanium oxide is not as great as indicated by the example.

DISCLOSURE OF THE INVENTION

[0008] It is an object of the present invention to realize the visible light operation of titanium oxide photocatalysts and to provide a photocatalyst which has higher visible light absorbing efficiency by using novel materials and without using expensive techniques such as ion implantation.

[0009] From experimental analysis and a theoretical study of optical properties of semiconductors using the first principle calculation, it was found that the nitrogen-containing titanium oxide semiconductors of the present invention form new levels within the band gap of titanium oxide. From this novel understanding, photocatalytic material exhibiting a strong photocatalytic activity under visible light in a wavelength region wider than that of titanium dioxide was developed by preparing said nitrogen-containing titanium oxide using a devised production method.

[0010] The photocatalytic materials according to the present invention have a Ti-O-N constitution in which nitrogen (N) is incorporated in titanium oxide crystals and exhibit photocatalytic activity in the visible light region. Therefore, they can exhibit photocatalytic activity similar to titanium oxide when using visible light as operating light. Moreover, because nitrogen is a very stable and non-toxic material, incorporation of nitrogen will not cause any problems during actual use.

[0011] Furthermore, it is suitable that nitrogen is incorporated by either one or a combination of substituting a nitrogen atom for an oxygen site of titanium oxide crystal, doping a nitrogen atom within, or at an interstitial site of a lattice of a titanium oxide crystal, and doping a nitrogen atom to grain boundaries of titanium oxide.

[0012] In addition, it is suitable that the photocatalytic materials according to the present invention incorporate nitrogen atoms doped in titanium oxide crystals where titanium atoms chemically bond to nitrogen atoms.

[0013] From the above, a photocatalyst which exhibits photocatalytic activity by absorbing visible light can be obtained. Thus, the photocatalyst can exhibit satisfactory photocatalytic activity even under solar or fluorescent light.

[0014] It is known that nitrogen elements can be incorporated into conventional titanium oxide photocatalysts during their production and treatment processes. For example, Japanese Patent No. 2917525 discloses the presence of nitro groups (-NO_2) derived from nitric acid used in surface treatment. Also, Japanese Patent No. 2865065 discloses the presence in titanium dioxide of nitrogen derived from nitric acid in a titanium oxide- sol- dispersed solution material, as observed by EPMA analysis.

[0015] However, conventional recognition is that this nitrogen is a contaminant and that compounds formed of the mixed nitrogen have a negative influence and have no novel effect on photocatalyst performance, especially the wavelength range of operating light.

[0016] The reason why this mixed nitrogen causes no novel effects on the wavelength range of operating light of photocatalytic substance is as follows.

[0017] This type of incorporated nitrogen atoms form only nitrogen oxides and organic substances inside the photocatalysts, and do not combine with titanium atoms. As a result, the mixed nitrogen atoms had no effects on optical properties as a semiconductor such as the band gap of titanium oxide.

[0018] In contrast, because the present invention is characterized in that the nitrogen atoms are substituted for some of the oxygen sites of titanium oxide crystals, doped into interstitial sites of lattices of a titanium oxide crystals, and/or doped to grain boundaries of titanium oxide, their XPS spectra are different from those of nitrogen atoms conventionally incorporated in titanium oxide.

[0019] Among these, it is especially desirable that there be a chemical bond between titanium atoms and nitrogen atoms in photocatalytic materials, and it is even more desirable that the constitution comprises substituting nitrogen atoms for some of the oxygen sites of basic titanium oxide crystals.

[0020] The characteristic of the nitrogen doped photocatalytic articles of the present invention may be detected through analysis of the chemical bond state of nitrogen atoms with XPS (X-ray Photoemission Spectroscopy). The nitrogen doped photocatalytic materials of the present invention are characterized in that a binding energy spectrum of the is shell of a nitrogen atom as measured using XPS has a peak in the region at 400eV or less.

[0021] More preferably, a binding energy spectrum of the is shell of a nitrogen atom in XPS is characterized by having a peak near 396 to 397 eV.

[0022] As a result, it is characterized by having an impurity level resulting from the substitution of nitrogen atoms for some of the oxygen sites of titanium oxide within the band gap between a valence band and a conduction band of titanium oxide.

[0023] Furthermore, it is suitable that the nitrogen concentration X expressed in atomic % is $0 < X < 13$. Nitrogen content is not especially limited, but is preferably over 0 and below 13% according to experiments. The suitable photocatalytic activity described above may be obtained with a nitrogen content in such a range.

[0024] In addition, as long as nitrogen is in the above-described state, the number of oxygen atoms may be either excessive or deficient. In particular, if nitrogen is incorporated in a state that titanium oxide is reduced, photocatalytic activity is displayed even in the longer wavelength visible light region. Atomic ratio Y, Z, and X for titanium, oxygen, and nitrogen should be in the range of $0.4 < Y / (X + Z) < 0.6$.

[0025] These effects can be realized with Ti-O-N in any combination of single crystals, polycrystals, or amorphous Ti-O-N. However, single crystals and polycrystals tend to exhibit a greater photocatalytic activity than does amorphous Ti-O-N.

[0026] Moreover, titanium oxide crystals may be present on the external surface side of the above-described photocatalytic materials. With such a configuration, internal photocatalytic materials are able to absorb visible light to

produce electrons and holes so that a photocatalytic action is exhibited by the titanium oxide crystals at the surface. As a result, visible light can be utilized as operating light with maintaining activities similar to conventional titanium oxide photocatalysts. For example, such a constitution is advantageous when it is desired to decrease the contact angle of water and to instill a hydrophilic property.

[0027] Moreover, it may be preferable that the XPS spectrum of Ti-O-N has a spectrum derived from an ammonium salt.

[0028] Moreover, it may be preferable that the surface of photocatalyst according to the present invention have mainly C axis crystal face orientation in practical use.

[0029] Photocatalysts may be employed such that they are formed on the whole or partial surface of a substrate. The substrate may be made of titanium oxide, silica, alumina, and inorganic oxides of their composites; titanium nitride, silicon nitride, aluminum nitride, and their composite nitrides; or organic substances such as composite oxynitride and fluororesin.

[0030] Furthermore, photocatalysts according to the present invention may have a form in which at least one of alumina, silica, zirconia, magnesia, calcia, calcium phosphate, amorphous titanium oxide, fluororesin, and the above materials further containing nitrogen is carried on the outmost surface of Ti-O-N.

[0031] The photocatalytic materials according to the present invention may be preferably manufactured by at least one of the following manufacturing processes:

- (1) formation as a thin film on a substrate by sputtering at least one of titanium oxynitride, titanium oxide, titanium nitride, and metallic titanium used as a target material in an atmosphere containing nitrogen gas;
- (2) formation as a thin film on a substrate by vaporizing or ion plating at least one of titanium oxynitride, titanium oxide, titanium nitride, and metallic titanium used as a vaporizing material in an atmosphere containing nitrogen gas;
- (3) formation by heat treating titanium oxide or hydrated titanium oxide in an atmosphere containing ammonia gas, nitrogen gas, or a mixture of nitrogen gas and hydrogen gas;
- (4) heat treating a titanium alkoxide solution in an atmosphere containing ammonia gas, nitrogen gas, or a mixture of nitrogen gas and hydrogen gas;
- (5) treating titanium oxide in a plasma containing nitrogen atom;
- (6) implanting nitrogen atoms in titanium oxide by ion-implantation;
- (7) formation as a thin film on a substrate by vacuum evaporating at least one of titanium oxynitride, titanium oxide, titanium nitride, and metallic titanium used as evaporating materials in an atmosphere containing nitrogen gas, followed by transfer to a different vacuum vessel by differential pressure;
- (8) performing, in an emulsion combustion method, spray combustion of emulsion in an atmosphere in which ions or molecules (except nitrate ion) containing nitrogen elements such as ammonia and hydrazine are present in an aqueous solution or suspension of metallic salts which is the aqueous phase in emulsion and in which the amount of oxygen introduced into a reactor is less than that (hereinafter referred to as the required amount of oxygen) with which combustion components (oil and surface active agents) contained in the emulsion completely burn, and
- (9) performing, in an emulsion combustion method, spray combustion of emulsion in an atmosphere in which nitrogen containing gas (except nitrogen gas) such as ammonia instead of ions or molecules (except nitrate ion) containing nitrogen atoms such as ammonia and hydrazine are contained in an aqueous solution or suspension of metallic salts which is the aqueous phase in emulsion and in which the amount of oxygen introduced into a reactor is less than the required amount of oxygen;
- (10) mixing titanium oxide and titanium nitride and heat treating this mixture at temperatures from 400 to 700°C; and
- (11) heat treating or plasma treating titanium nitride or titanium oxynitride in an oxidation atmosphere containing oxygen, ozone, a water molecule, or a hydroxyl group.

[0032] Next, specific aspects of the structure of the photocatalytic materials of the present invention will be described.

[0033] Fig. 6 shows a spectrum of the 1s shell of nitrogen atom by XPS analysis using a Mg-K α X-ray. As shown in this figure, nitrogen atoms contained in conventional titanium oxide photocatalysts differ from those in the photocatalysts of the present invention in their chemical bond state. That is, as described above, nitrogen atoms contained in conventional titanium oxide form oxides and organic substances, whereas, in the photocatalysts of the present invention, nitrogen atoms show bonds to Ti atoms. This bonding of nitrogen in the present invention shows that the nitrogen is substituted for the oxygen sites in titanium oxide crystals, and not simply doped between lattices or interstitial sites of oxygen in crystals or between grains.

[0034] In addition to physical experiments, the present inventors also studied the photocatalytic materials of the present invention using theoretical calculation. More specifically, electronic state and optical characteristics of semiconductor photocatalysts were evaluated by the FLAPW (full-potential linearized-augmented-plane-wave) process, which is one of the first principle calculation methods. As models, TiO_{1.75}X_{0.25} (X = N, B, C, F, P, S) unit cells wherein

anions were substituted for some of the oxygen sites of anatase titanium oxide were used.

[0035] Fig. 7 shows the calculated density of state (DOS) of Ti-O-X semiconductor. It was found that the position at which a new impurity level is formed varies with substitution species, and that the position also varies according to the ionicity of these substitution species. In this figure, a valence band rises on the minus side from energy 0 eV in each density of state, a conduction band of titanium oxide rises on the plus side from the vicinity of 2.5eV, and the interval between them corresponds to a band gap. Because the reduction level of water is in the vicinity of the conduction band of titanium oxide, it is preferable to create a narrower band gap by moving the valence band closer to the conduction band of titanium oxide rather than the moving conduction band of titanium oxide.

[0036] It was found from the above that, from the viewpoints of both narrowing the band gap and of smooth mixing degree of impurity levels and the titanium oxide band, N (nitrogen) and S (sulfur) are especially preferable as substitution species X for enabling operation under visible light.

[0037] Fig. 8(a) and Fig. 8(b) show energy E (eV) dependency of the imaginary part of dielectric function (ϵ_{2xy} , ϵ_{2z}) obtained by calculation. Fig. 8 (a) shows the energy dependency in the xy direction (vertical direction to C axis) for titanium oxide crystals, while Fig. 8 (b) shows dependency in the z direction (C axis direction).

[0038] This imaginary part of dielectric function corresponds to the wavelength dependency of optical absorption characteristics. In both Ti-O-N and Ti-O-S, absorption edges are shifted to the lower energy side, that is, the longer wavelength side than those of titanium oxide. This results suggest that visible light operation is possible by substitution of one of N and S or both in titanium oxide. Moreover, it can be seen from comparison of Fig. 8 (a) with Fig. 8 (b) that optical anisotropy is strong in both titanium oxide and Ti-O-X (X=N or S), and it can be understood from this result that dependency of a photocatalytic activity for a crystal face is strong.

[0039] Especially, it is also found that longer wavelength visible light is absorbed by Ti-O-N having a C axis orientation. Because the absorption edge in the xy direction is noticeably shifted to the visible light direction, it can be seen from this that the photocatalytic article of the present invention is suitable when the surface crystal face is mainly oriented in the direction of a C axis. Because light vertically incident to the surface has components of an electric field in propagation and vertical direction (the direction vertical to the surface), visible light can be efficiently absorbed when the surface is in the direction of the C axis crystal because of the light absorption characteristics in the xy direction in Fig. 8 (a).

[0040] Changes in the electronic state of titanium oxide by substitution of these anions X are mainly due to the differences between the atomic levels between O, N, or S for titanium atom. Therefore, if the Ti-X bonding exists in photocatalytic articles in which titanium oxide is a substrate, the effects by substitution of the anions of the present invention are realized when other anions X are substituted for oxygen (O) as in the model used for the above calculation, when anions X intrude into lattices of a crystal by warping the lattice form, when anions X are present in grain boundaries, or when these latter situations are combined.

[0041] Now, as described above, there are some anions which may substitute for some of the oxygen sites of titanium oxide. When substituting nitrogen atoms for some of the oxygen sites, the electronic state of a semiconductor changes and new absorption bands are formed within band gaps. On the other hand, substituting, for example, cations such as Al, Cr for some of the oxygen sites is impractical, considering charge balance. Substituting nitrogen and fluorine for titanium sites is also impractical.

[0042] On the other hand, elements such as carbon and boron may substitute for not only the oxygen sites, but also for the titanium sites. When this occurs, the electronic states entirely differ according to the location of the substitution, even when the same atom is substituted.

[0043] Moreover, in contrast to semiconductors such as silicon, in oxide semiconductors like titanium oxide which are formed of more than two elements, adjacent atoms and the electronic states both differ according to the position of the doped impurities. Thus, description of impurities doped into a material without a description of the locations or sites, such as lattices or grain boundaries, where the impurities are located, is not sufficient to specify a material.

[0044] Furthermore, although in conventional examples, the tendency of doping effects was sometimes described by the valency of dopant, this is not significant because, as described above, the electronic states are completely dependent on the position into which dopant enters.

[0045] Therefore, when the state of nitrogen atoms of the present invention is discussed, it is not meaningful to classify the performance by means of the valence number such as pentavalence and trivalence. The present invention was completed by making absorption of visible light possible only when there is a chemical bond of Ti-N in Ti-O-N as a state of nitrogen atom and by finding exhibition of photocatalytic characteristics. Especially among these, the performance is highest when substituting nitrogen atoms for certain oxygen sites of titanium oxide.

[0046] The position of XPS peak of N1s shell when Ti-N bonding remains in titanium oxide maybe estimated from data in scientific literature such as "National Institute of Standards and Technology (NIST)". The peak of TiN is observed near 396-397 eV. In addition, N.C. Saha et al describe XPS data of Ti-O-N in "J. Appl. Phys., 72 (7), pp.3072 (1992)". Although nitrogen content in that example is considerably greater than that in the photocatalytic materials of the present invention, the N1s shell peak of Ti-O-N is observed near 396-397 eV similarly to TiN of NIST.

[0047] On the other hand, in the Ti-O-N of the present invention, the position of XPS peak when nitrogen atoms are doped in an interstitial site of lattices of titanium oxide is not known as there are no published reports. The position of XPS peak may then be analyzed by FLAPW which is one of the most accurate first principle calculation methods. This gives quasi-quantitative calculation results. For calculation, N substitution type (a total of 24 atoms) and N interstitial type (a total of 25 atoms) models were used with 24 atom models of anatase titanium oxide as a basis. Table 1 shows results of these tests.

Table 1

Energy difference from Ti2p3/2 peak (eV)			
	Ti-O-N (Substitution)	Ti-O-N (Intrusion)	Organic Compound Nitro Group
Calculation	-63.63	-63.38	-
Experiment	-62.8	(Unclear)	-59.1

[0048] The XPS peak of the interstitial type N1s shell of intrusion Ti-O-N was obtained at a position 61.38eV lower than the Ti2p3/2 peak. On the other hand, the XPS peak of the substitution type N1s shell was obtained at a position 63.63eV lower than Ti2p3/2 peak. That is, the result was obtained that the peak of interstitial type N1s shell appears at a position 2.25eV higher than that of substitution type N1s shell because the combination with an oxygen atom is more dominant in the interstitial type than in the substitution type.

[0049] On the other hand, in the XPS experiment of the Ti-O-N photocatalysts of the present invention, a Ti-N combination peak near 397eV and a peak near 400eV, which is higher by about 3eV, were obtained. Therefore, it is considered from these results that a peak observed near 400eV in the experiment indicates N atoms in the interstitial site of titanium oxide lattices or impurity nitrogen (according to NIST data) forming a carbon compound and a nitro group or the like.

[0050] From the above experimental results and from theoretical calculation, it can be understood that the following points are significant for the Ti-O-N visible light operation photocatalysts of the present invention.

[0051] The Ti-O-N visible light operation photocatalysts of the present invention include photocatalytic materials in which nitrogen atoms are contained in titanium oxide crystals by either one or a combination of substituting nitrogen atoms for some of the oxygen sites of titanium oxide crystals, doping nitrogen atoms at interstitial sites of lattices of a titanium oxide crystal, or doping nitrogen atoms to grain boundaries of titanium oxide. Then, the XPS peak of N1s shell is observed at 400eV or less. It is especially desirable that nitrogen atoms have a chemical bond between titanium atoms of titanium oxide and Ti-N. Furthermore, it is desirable that nitrogen atoms are present as substitutions for some of the oxygen sites of titanium oxide crystals. Then, the XPS peak of N1s shell is observed near 396 to 397eV.

[0052] Moreover, although for the above calculation, the effects of anion doping were studied using lattices of an anatase type titanium oxide crystal, similar effects are obtained also in the anion doping to rutile type, brookite type, and amorphous type titanium oxides.

[0053] The composition ratio of these powders and films exhibiting visible light operation photocatalytic performance will be described in the examples below in which $\text{Ti}_{33.9}\text{O}_{64.7}\text{N}_{1.4}$, $\text{Ti}_{34}\text{O}_{65}\text{N}_1$, and $\text{Ti}_{31}\text{O}_{67}\text{N}_2$ were produced. When N in a state of Ti-N bond is realized, visible light operation photocatalysts are obtained in either oxygen excess or reduced titanium oxides. The atomic number ratio Y, Z, and X for titanium, oxygen, and nitrogen may be in the range of $0.4 < Y/(X+Z) < 0.6$.

BRIEF DESCRIPTION OF THE DRAWINGS

[0054]

Fig. 1 shows the constitution of an Embodiment 1 according to the present invention.

Figs. 2(a) and 2(b) are views showing the crystalline phase of titanium oxide.

Figs. 3(a) and 3(b) show the constitution of an Embodiment 2 according to the present invention.

Figs. 4 (a) and 4 (b) are views showing an Embodiment 3 according to the present invention.

Figs. 5(a), 5(b), and 5(c) are views showing an Embodiment 4 according to the present invention.

Fig. 6 is a view showing a binding energy spectrum (XPS spectrum) of the 1s shell of a nitrogen atom in a photocatalytic material according to the present invention.

Fig. 7 is a view showing the state density of Ti-O-X obtained by substituting X for certain oxygen sites.

Figs. 8(a) and 8(b) are views showing the energy dependency of the imaginary part of a dielectric function.

Fig. 9 is a view showing the wavelength dependency of the light absorbance of the photocatalysts.

Fig. 10 is a view showing the contact angle of water on a film surface.

Fig. 11 is a view showing the characteristics of a lamination type photocatalyst.

Fig. 12 is a view showing comparison of the decomposition performance of organic substances on photocatalysts.

Figs. 13(a), 13(b), and 13(c) are views showing the relationship between photocatalyst performance under visible light and the bonding state of nitrogen atoms in an Embodiment 4.

Figs. 14(a) and 14(b) are views showing spectra of visible light source and the photocatalytic activity.

Fig. 15 is a view showing light absorption spectra of the photocatalytic materials according to an Embodiment 10 of the present invention.

Fig. 16 is a view showing the binding energy spectrum (XPS spectrum) of the is shell of a nitrogen atom in a photocatalytic material of Embodiment 10.

Fig. 17 shows the constitution of an ultra fine grain film producing equipment in an Embodiment 13 according to the present invention.

Fig. 18 shows the light reflection spectra in an Embodiment 16 according to the present invention.

Fig. 19 is a view showing the photocatalytic activity under fluorescent light of a photocatalytic material according to Embodiment 1 of the present invention.

Best Mode for Carrying out the Invention

[0055] In the following, preferred embodiments of the present invention will be described with reference to the drawings.

Constitution of the Photocatalytic Material

Embodiment 1

[0056] Fig. 1 shows the constitution of an Embodiment 1 according to the present invention. In this Embodiment 1, a Ti-O-N film 12 of the photocatalytic material is formed on a SiO₂ substrate 10. The structure of this Ti-O-N film 12 is such that nitrogen atoms substitute some of the oxygen sites in the titanium oxide crystals. A structure obtained by doping nitrogen atoms at the interstitial sites of lattices of a titanium oxide crystal or a combination of both may also be employed. The composition ratio of each element in Ti-O-N film 12 is, for example, Ti₃₁O₆₇N₂. Thus, Ti-O-N film is basically a titanium oxide crystal and has the constitution of containing N in a titanium oxide film. In addition, rutile and anatase, for example anatase + rutile, may be employed as the crystalline phase of a titanium oxide crystal.

[0057] Fig. 2(a) shows rutile type titanium oxide crystals and Fig. 2 (b) shows the crystalline unit lattices of anatase type titanium oxide. In these figures, small and large ○ symbols are used to show Ti and O, respectively. Ti-O-N is formed by substitution of N for a part of this O or by entrance of N into a space within crystal lattices or grain boundaries of titanium oxide crystals.

[0058] An example manufacturing process for producing such photocatalytic materials will be described. In this example, Ti-O-N film 12 is formed by RF magnetron sputtering.

[0059] SiO₂ substrate 10 and a titanium oxide target are set in a vacuum chamber of a RF magnetron sputtering device. Then, appropriate amounts of N₂ gas and inert gas (for example, Ar gas) are introduced into the vacuum chamber to conduct sputtering in (N₂ + Ar) plasma. Ti-O-N film 12 is accumulated on a SiO₂ substrate 10. As the substrate 10, various materials, such as ceramic, can be utilized.

[0060] During sputtering, the whole gas pressure may be set at, for example, 0.52Pa and N₂ partial pressure in the range of 0%<N₂ partial pressure≤100%, but the suitable ratios range from about 20 to 60%.

[0061] After the depositing of the Ti-O-N film 12 by sputtering, heat treatment (annealing) is performed for crystallization. For example, crystallization may be conducted by heat treating in a nitrogen atmosphere at 550°C for about two hours. That is, although simple film deposition yields an amorphous structure containing polycrystals, through heat treatment it is possible to obtain poly- and single- crystallization and further to give titanium and nitrogen having chemical bonds. Moreover, although the post-heat-treating may be eliminated by forming Ti-O-N film 12 while heating the SiO₂ substrate 10, the resulting photocatalytic performance is inferior to that which results when annealing is performed after deposition of the film.

[0062] Moreover, nitrogen content of the Ti-O-N film was 6.6 at % before heat treatment and 1.4 at % after heat treatment for film deposition by N₂ partial pressure 20%, and 12.7 at % before heat treatment and 0.5 at % after heat treatment for film deposition in N₂ partial pressure 100%. In addition, in case of filmdeposition in N₂ partial pressures of 40% and 60%, nitrogen content in Ti-O-N film after heat treatment was 1.4 at % and 1.5 at %, respectively.

[0063] All these Ti-O-N films exhibited photocatalytic activity. It was found that nitrogen suitable content of Ti-O-X film was 0<X<13 when the ratio in atomic percent was taken as X%. Moreover, as a photocatalytic activity of Ti-O-N

film; that after heat treatment is superior and as the nitrogen concentration after heat treatment, several percent or less, and more preferably 2% or less, is desirable.

[0064] Furthermore, although in the above example, Ti-O-N film 12 was deposited using the titanium oxide target in plasma of Ar gas containing N₂, the film may be deposited in plasma containing O₂ gas with TiN (titanium nitride) target.

Further, as a target, titanium oxide + TiN may also be used.

[0065] Further, Ti-O-N film 12 may also be deposited by vacuum evaporation in (N₂ + O₂) gas with Ti ingot.

[0066] Moreover, although in the above example, Ti-O-N as a photocatalytic material in the form of a thin film was described, Ti-O-N can not only be applied in a thin film, but can also be included in binder materials for painting such as silica, alumina, fluororesin, those containing nitrogen, and compound complexes thereof in which fine grain Ti-O-N based Ti-O-N is mixed and in silica, alumina, fluororesin or those containing nitrogen, or compound complexes of them used as internal base materials, on the whole surface or a part of the external surface side of which Ti-O-N is formed.

[0067] Furthermore, it is possible for Ti-O-N to be prepared by various methods of preparing fine grain, a sol gel method, and a chemical reaction method with the above manufacturing process as a base. Specific examples will be described later.

[0068] The Ti-O-N photocatalytic material obtained in this way exhibits a photocatalytic activity by incidence of visible light. That is, the Ti-O-N photocatalytic material exhibits a photocatalytic activity when irradiated with visible light as well as ultraviolet light, resulting in improvement in a hydrophilic property (decrease in the contact angle of water) and the ability to decompose organic substances. Hence, not only can Ti-O-N be used with visible light as the operating light, but also, as a result, there is notable improvement in the photocatalytic activity when the material is irradiated with light in the ultraviolet to visible region. In particular, it is markedly superior to a titanium oxide photocatalyst in the ability to decompose organic substances.

Embodiment 2

[0069] Fig. 3 shows the constitution of an Embodiment 2 according to the present invention. In Fig. 3 (a), Ti-O-N film 12 is formed on the SiO₂ substrate 10, and titanium oxide film 14 is formed thereon. Moreover, although in Fig. 1, a two layer laminated structure is shown, the boundaries of both may become indistinct in the course of heat treatment or the like, resulting in the constitution that N gradually decreases toward the surface. That is, Ti-O/ Ti-O-N film of gradient composition is formed in which the amount of N atom is less at positions nearer to the surface, and in which titanium oxide is exposed at the outmost surface, though it is also possible to maintain a distinct boundary between the Ti-O-N and titanium oxide films.

[0070] Moreover, gradient composition can be produced not only by heat treatment after lamination layer formation of Ti-O-N and titanium oxide films, but also by changing the gas composition in an atmosphere according to the deposition state of the film. That is, it is possible to form titanium oxide on the surface side by gradually decreasing the N₂ partial pressure of the atmosphere.

[0071] With such a constitution, visible light is absorbed in the Ti-O-N region (Ti-O-N film 12) near the substrate 10 to produce electrons and holes, which are supplied to titanium oxide (titanium oxide film 14). In this manner, a photocatalytic activity is exhibited at the surface of the titanium oxide film 14.

[0072] Hence, in the titanium oxide film, similar to the conventional example, a photocatalytic activity is produced using visible light as operating light. Because the hydrophilic property (contact angle θ) of TiO₂ films is superior to that of Ti-O-N, improvement in hydrophilic property by the TiO₂ film deposited onto the surface can be achieved using visible light as the operating light. That is, with the configuration of this embodiment, it is possible for hydrophilic property to be exhibited by irradiation of only visible light and to improve the long-term hydrophilicity of the TiO₂ film.

[0073] Furthermore, it is suitable that the Ti-O/ Ti-O-N photocatalyst of gradient composition, as shown in Fig. 3 (b), be in the form of a grain having Ti-O-N part 22 on the inside and TiO₂ part 24 on the outside. It is suitable that such a photocatalyst in the form of a grain is mixed in a binder for paints such as silica, alumina, fluororesin, those containing nitrogen, or complex oxides of them and is utilized like paint.

Embodiment 3

[0074] Figs. 4(a) and 4(b) show the constitution of an Embodiment 3 of the present invention. The inside of the photocatalytic substance of this Embodiment is titanium oxide TiO₂ and the outmost surface side of the outside is Ti-O-N. In addition, Ti-O-N layer at this time may cover the entire outmost surface or form only a part of the surface. Such constitution is mainly realized when nitride treatment is performed from the surface side by after treatment such as heat treatment and plasma treatment using titanium oxide powder and film as a starting material.

Embodiment 4

[0075] Fig.5 (a), 5 (b), and 5 (c) show the constitution of an Embodiment 4 of the present invention. When the Ti-O-N photocatalyst of the present invention is employed by mixing into an organic fiber and plastic, a problem occurs that the above-described organic fiber and plastic is decomposed by its direct contact with the Ti-O-N photocatalyst. In Embodiment 4, to solve this problem, ceramic with a lower catalytic activity is carried on the surface of the Ti-O-N photocatalyst in an island, needle, or mesh form. Figs. 5(a), 5(b), and 5(c) respectively illustrate island, mesh, and needle configurations. By arranging ceramic with a low activity on the surface in this manner, it is possible to control the decomposition of an organic fiber and plastic through the ceramic material with which it is in contact. Ceramics include alumina, silica, zirconia, magnesia, calcia, calcium phosphate, amorphous titanium oxide, fluororesin, and their nitrogen or compound complexes.

Device for Manufacturing Photocatalyst

[0076] From the results showing the features of the structure described in the above Embodiments 1 to 4, it is also necessary to devise a manufacturing process of the photocatalysts of the present invention. That is, it is necessary to select such a condition that nitrogen atoms tend to have a negative valency. This can be accomplished, for example, through use of:

1. a reducing atmosphere, and
2. a vacuum vessel to recombine and reconstitute nitrogen containing titanium oxide after separating Ti, O, and N atoms, from which a material is formed, by ion beam and plasma irradiation.

[0077] In the manufacturing processes of the present invention, from these standpoints, manufacturing processes of nitrogen doped titanium oxide presenting a high photocatalytic activity also in the visible light region will be described.

[0078] Moreover, the crystalline structure prepared in the present invention which is a basis of nitrogen doped titanium oxide may be any of anatase, rutile, and brookite.

[0079] Specific example manufacturing processes will be described in the following Embodiments 7 to 14.

Example Photocatalysts

[0080] In the following, real characteristics of example visible light operation type photocatalysts of the present invention will be described.

Example 1

[0081] In this example, a Ti-O-N film corresponding to the above Embodiment 1 was employed. Using an RF magnetron sputtering device, Ti-O-N film was formed on a substrate by sputtering a titanium oxide target in ($N_2 + Ar$) plasma. The substrate was SiO_2 . The whole gas pressure during sputtering was 0.52Pa and N_2 partial pressure varied between 0 and 100%. The deposition rate was 3 to 8 nm/min. After depositing, the Ti-O-N film was crystallized by heat treating in a nitrogen atmosphere at 550°C for two hours. The crystalline phase in the Ti-O-N film was anatase + rutile, and TiN was not observed. In addition, the composition ratio after heat treating of a film sputtered in 40% $N_2 + Ar$ was found to be $Ti_{31}O_{67}N_2$ by XPS (X-ray electron spectroscopy) analysis. The peak of the N1s shell spectrum of nitrogen was observed near 397eV and near 400eV and it was also confirmed that there is a Ti-N bond in the Ti-O-N phase.

[0082] In order to examine optical characteristics of this Ti-O-N film, the wavelength dependency of absorbance was measured. The results are shown in Fig. 9. A comparison between anatase + rutile TiO_2 (Ti-O) film and Ti-O-N film with the same grain diameter D to 15 nm reveals that the Ti-O-N film can absorb light with a longer wavelength than the Ti-O. Ti-O-N film also considerably absorbs light with a wavelength of about 400nm. It was found from this that the Ti-O-N film is a semiconductor which absorbs visible light to produce electrons and holes.

[0083] To examine the photocatalytic activity of this Ti-O-N film when irradiated with only visible light, the light irradiation dependency of the contact angle θ of water at the surface was determined.

[0084] Fig. 10 shows the contact angle θ of water at the film surface when the Ti-O-N film, which was prepared by varying N_2 partial pressure between 0 and 100% and was heat treated at 550°C, is irradiated by a Xe lamp for one hour (the symbol in the figure is \square). For pure titanium oxide (N_2 partial pressure is 0%), the hydrophilic property of the contact angle $\theta < 10^\circ$ develops by a photocatalytic action with ultraviolet light with a wavelength of 200 nm or longer. On the other hand, the θ of Ti-O-N film prepared in the presence of N_2 increases with increasing N_2 partial pressure on sputtering due to the effect of N. These optimum θ values are the essential values for each Ti-O-N film composition.

[0085] In Fig. 10, the characteristics when these Ti-O-N films were irradiated for one hour with only visible light

(wavelength $\lambda > 400\text{nm}$) is indicated with the symbol \bigcirc . Here, the ultraviolet light region consisting of light with wavelengths less than 400nm was optically filtered. As a result, the θ values of a film prepared in N_2 partial pressure 20 to 60% were also reduced to approximately optimum values when irradiated with only visible light. On the other hand, in a pure titanium oxide film, the value for θ is considerably large when the film is irradiated with only visible light. In can be seen that Ti-O-N film exhibits a photocatalytic action when irradiated with visible light.

Example 2

[0086] In Embodiment 1, because the contact angle at the surface of Ti-O-N film becomes small when irradiated with only visible light, it was clarified that Ti-O-N is a photocatalyst which is operated even when irradiated with only visible light. However, when, for the contact angle of this film, only the absolute value of the contact angle is compared from the standpoint of application utilizing a hydrophilic property such as a mirror and a window, the Ti-O-N film of the present invention is inferior to a titanium oxide film. In this Example 2, a photocatalyst having a laminate type film constitution of Ti-O-N film corresponding to the above Embodiment 2 was compared with a titanium oxide film.

[0087] The constitution of Embodiment 2 is as shown in Fig. 3 (a). The photocatalyst of the present example was formed in such a way that first a Ti-O-N film 12 of 2200\AA and then a titanium oxide film of 1000\AA were deposited on a SiO_2 substrate and then heat treatment was performed in an oxygen atmosphere at 550°C for 90 minutes. Through this process was formed a Ti-O/ Ti-O-N film of gradient composition in which the concentration of N atom is less nearer to the film surface and in which titanium oxide is exposed at the outmost surface. XPS examination of the distribution of nitrogen atoms for every 50\AA in the depth direction of the film revealed no nitrogen atoms present up to a depth of 50\AA from the outmost surface and that the atomic % ratio of nitrogen progressively rose at deeper levels. The ratio of nitrogen in atomic % immediately before Si of the substrate begins to be observed is 2.9%. In addition, the peaks of the N1s shell spectrum of nitrogen at a deeper place than 100\AA were observed both at 397eV and at 400eV and it was also confirmed that a Ti-N bond is present in a Ti-O-N phase.

[0088] Fig. 11 shows a measurement example of the contact angle θ of water. Under irradiation of visible light with a wavelength of 400nm or longer, no reduction in the contact angle in the titanium oxide film was observed. On the other hand, for Ti-O/ Ti-O-N film of gradient composition, the contact angle was reduced even when irradiated with visible light with a 400nm or longer wavelength, and shows a smaller value than that of a titanium oxide film. In addition, this effect was maintained for a relatively long time. That is, after a contact angle θ as small as that of a titanium oxide film was obtained under irradiation with a Xe lamp, photocatalytic reaction to the visible light component of a fluorescent light was maintained even when the catalyst was allowed to stand on a table under fluorescent light for seven days. No great deterioration of the contact angle of water, like a titanium oxide film, was observed.

[0089] Moreover, from the results of Example 2, it was confirmed that there are also equal characteristics when the total film thickness is 1600 and 2500\AA and in addition, the similar effects are also shown when a sharp interface instead of gradient composition is formed with the composition varying in successive steps.

[0090] Furthermore, with a photocatalyst according to Embodiment 2, because ultraviolet and visible light are absorbed, in addition exhibiting a hydrophilic property, additional functions such as sterilizing and decomposing toxic substances such as dioxin and nitrogen oxides are obtained. While these functions can also be obtained using a titanium oxide, with the present invention additional functions are realized with a higher efficiency than obtained through use of a titanium oxide film.

Example 3

[0091] Example 3 compares the performance of decomposing organic substances at the film surface of Embodiments 1 and 2. Fig. 12 shows the amount of decomposition of organic substances applied to the surface of each catalytic film when irradiated with light. For comparison, the results of a commercial titanium oxide photocatalytic film with equal film thickness prepared by a sol gel method are collectively shown. The light source was a Xe lamp, the irradiation wavelength region was adjusted with a sharp cut filter, and further a heat absorbing filter was used to prevent a rise in the temperature of a sample. The power of irradiated light was about $13\text{mW}/\text{cm}^2$ in the ultraviolet light region.

[0092] When irradiated with only visible light with a wavelength $\lambda > 400\text{nm}$, the performance for decomposing organic substances for the Ti-O-N films prepared according to Embodiments 1 and 2 are both superior to that observed for the titanium oxide film, the decomposition rate for the gradient composition film was especially markedly superior, about four times that for the titanium oxide film. In addition, when irradiated with ultraviolet-visible light with $\lambda > 200\text{nm}$, the performance of decomposing organic substances for the Ti-O-N film in Embodiment 1 is very great compared with the titanium oxide film. The decomposition rate of organic substances for the Ti-O-N film prepared at N_2 partial pressure 40% is at least over four times that of the titanium oxide film (N_2 partial pressure 0%). It can be understood from these results that the Ti-O-N film of the present invention exhibits the most superior performance for decomposing organic substances among photocatalytic actions.

[0093] Moreover, the results showed that a sputtering film prepared in 40% N₂-Ar has a decomposing rate four times that of a commercial oxide film when irradiated with visible light with $\lambda > 400\text{nm}$, and eight times under light with $\lambda > 200\text{nm}$ higher than a commercial titanium oxide film, even under an intensity of 5mW/cm^2 , which is approximate to that at the time of a clear summer day in a temperate climate.

Example 4

[0094] Example 4 was prepared by nitriding a titanium oxide powder as an initial material. A commercial rutile type titanium oxide powder (Ishihara Sangyo Kaisha, Ltd., TTO-55 (N)) treated in a mixed gas of ammonia and argon at 600°C for three hours was used. The photocatalytic performance was evaluated by the change of absorbance of an aqueous methylene blue solution at $\lambda=670\text{nm}$ after irradiation with visible light for 10 hours. The light source used was a 10W fluorescent tube (Matsushita Electric Works, Ltd., FL10N) to which was attached an ultraviolet cut filter (Fujifilm, SC42) such that visible light with λ approximately $\geq 400\text{nm}$ was irradiated. Ultraviolet intensity was $0.0\mu\text{W/cm}^2$ as measured using Topcon light-intensity meters UVR-2 and UD-36). In addition, when measuring photocatalysts, the photodecomposition of methylene blue in the absence of the photocatalysts and the adsorption in the dark or the effects of absorbance changes due to photoadsorption were removed.

[0095] The spectrum of N1s shell due to XPS was analyzed using Mg-K α and X-ray. The horizontal axes of Fig. 13 (a), Fig. 13(b), and Fig. 13(c) show the composition ratio of N in which a peak is seen near 397eV and which has a Ti-N bond, that of N which has a peak near 400eV , and the proportion of N having a Ti-N bond among the whole composition ratio of N in photocatalyst powders, respectively. From Fig. 13(a) and Fig. 13(c) it can be seen that photocatalytic performance under visible light irradiation improved with increasing N having a Ti-N bond. On the other hand, N having no Ti-N bond in Fig. 13(b) had no effects on photocatalytic performance under visible light irradiation. N in this Fig. 13 (b), as described above, is considered to be nitrogen atoms mainly forming an organic compound and a nitro group. It is found from these results that forming N having a Ti-N bond in Ti-O-N in which a peak is observed near 397eV is necessary for visible light operation of a photocatalyst.

[0096] Similar effects were also obtained when anatase type titanium oxide (Ishihara Sangyo Kaisha, Ltd., ST-01) was used as an initial material. Similar effects were again obtained when performing similar treatment using an amorphous titanium oxide powder. In such a configuration, there is also an effect that the state of N atoms is easier to control than when anatase and rutile crystalline powders are used as an initial material.

[0097] Furthermore, similar effects were also obtained when a titanium oxide powder was treated in plasma containing nitrogen atoms at a higher temperature than room temperature. Photocatalytic performance was found to be inferior in substances plasma treated at room temperature.

Example 5

[0098] From Example 4 it could be seen that the photocatalytic substance of the present invention can be realized by post-treating a titanium oxide powder. However, when a titanium oxide powder with large grain diameter or a thick film of titanium oxide is nitrided after production, the inside of the photocatalytic substance may be a titanium oxide and the outermost surface side of the outside maybe Ti-O-N, depending on treatment conditions.

[0099] By mixing colloidal silica and additives in a commercial titanium oxide powder (Ishihara Sangyo Kaisha, Ltd., ST-01), a simple coating solution was prepared. The solution was applied to a glass substrate form and dried, and then the substrate was subjected to heat treatment in air at 150°C for 30 minutes. Cross section observation by SEM (scanning electron microscope) showed that the film thickness was 500nm . Subsequently, this film was heat treated in a flow of ammonia gas 75sccm and argon gas 100sccm at 550°C for 30 minutes. As a result of this treatment, the whitish transparent film was changed into a yellowish transparent film. Structural analysis by X-ray diffraction and depth direction analysis by XPS of this revealed that it has Ti-O-N and Si-O-N at the film surface, titanium oxide and silicon oxide near the glass substrate, and gradient composition, with the nitrogen composition ratio decreasing from the outermost surface through the inside of the film. The photocatalytic characteristics of this film was evaluated. After the light transmission characteristics of the film were determined in the wavelength range of 400 to 750nm , the film was immersed in an aqueous $500\mu\text{M}$ methylene blue solution for 15 minutes and then dried in a dark location. After the light transmission characteristics were again determined, visible light from a 10W fluorescent tube (Matsushita Electric Works, Ltd., FL10N) to which an ultraviolet cut filter (Fujifilm, SC42) was attached was irradiated for 18 hours. The methylene blue (MB) decomposition rates after irradiation for 18 hours obtained by determining the light transmission characteristics were 8% for a titanium oxide coating film and 46% for Ti-O-N film of gradient composition.

[0100] Similar experiments were performed using a powder. An anatase titanium oxide powder (Furukawa Co., Ltd., FA-55W) with an average primary grain diameter of $0.118\mu\text{m}$ was heat treated in a gas flow of ammonia gas 400sccm and argon gas 200sccm at 550°C for 30 minutes. As a result of this treatment, the white powder was converted into a yellowish powder. In a grain with a large grain diameter partially nitrided by treatment in this manner, as shown in Fig.

4 (a), the inside of the grain was titanium oxide containing no nitrogen, the outermost surface side was Ti-O-N, and the nitrogen composition ratio continuously varied along the diameter of the grain. Using this powder, the characteristics of decomposition by visible light for an aqueous methylene blue solution were determined. To about 5cc of an aqueous 10 μ M methylene blue solution in a test tube, about 0.05g of a titanium oxide powder or a Ti-O-N powder was added and this mixture was irradiated with visible light while being stirred. The light source used was a 10W fluorescent tube (Matsushita Electric Works, Ltd., FL10N) to the circumference of which an ultraviolet cut filter (Fujifilm, SC42) was attached and visible light with a λ approximately \geq 400nm was used. The distance to the light source was 1 cm. Ultraviolet intensity was 0.0 μ W/cm² (the light-intensity meter made by TOPCON CORPORATION, UVR-2 and UD-36 were used). After irradiation for 72 hours, the solution containing the titanium oxide powder was slightly decolorized, whereas the solution containing the Ti-O-N powder was decolorized to be approximately colorless and transparent.

[0101] Ti-O-N phase formed by the treatment in this embodiment may cover the whole outmost surface of a grain, or may be formed on only a portion of the surface.

Example 6

[0102] When the Ti-O-N photocatalyst of the present invention is mixed into an organic fiber and plastic, a problem occurs in that the organic fiber and plastic is decomposed by its direct contact with Ti-O-N photocatalyst. To solve this problem, it was found effective that ceramic with a lower catalytic activity be carried on the surface of the Ti-O-N photocatalyst. However, when the entire surface of the Ti-O-N is covered with ceramic, photocatalytic effects are degraded because direct contact of Ti-O-N with substances to be oxidized or reduced photocatalytically is prevented. To avoid this, the present invention can be configured such that ceramic is carried in island, needle, or mesh forms as shown in Fig. 5(a), 5(b), and 5(c)

[0103] Example preparation of such a structure will next be described. First, a case using a hydrolysis method of metal alkoxide will be described. In hydrophobic organic solvents such as aromatic hydrocarbons such as benzene, toluene, and xylene or petroleum fraction such as kerosine and hexane to which alcohol such as methanol, ethanol, n-propanol, isopropanol, and n-butanol are added, Ti-O-N particles on the surface of which water is adsorbed are dispersed, hydrophobic organic solvents in which metal alkoxides such as alumina, silica, zirconia, magnesia, calcium, titanium are dissolved are added, and local hydrolysis of metal alkoxides is allowed to occur on said particle surface. Thereafter, by drying or sintering as necessary, ceramic with a lower catalytic activity than Ti-O-N may be formed in island, needle, or mesh shapes.

[0104] Alternatively, oxides of alumina, silica, zirconia, magnesia, calcium, and titanium or those containing nitrogen may be carried in island, needle, or mesh forms on Ti-O-N powder and film or a Ti-O-N coated substrate by the methods such as sputtering, vacuum evaporating, ionplating, and CVD.

[0105] Moreover, oxide ceramic of alumina, silica, zirconia, magnesia, calcium, and titanium and fluororesin may be carried in island, needle, or mesh forms on the titanium oxide surface by the above hydrolysis of alkoxide, sputtering, vacuum evaporating, ionplating, and CVD methods, and then by heat treatment and plasma treatment carried out in an atmosphere containing ammonia or nitrogen gases, nitrogen containing ceramic with a lower activity may be formed in island, needle, or mesh forms on the Ti-O-N surface.

[0106] In the resulting photocatalytic grain, ceramic with a lower activity as a photocatalyst is attached to the surface of a titania grain in island, needle, or mesh form. Thus, when employed with mixing into an organic fiber and plastic, it is the ceramic with a lower activity that comes in contact with the organic fiber and plastic. Then, it is possible to adsorb pollutants in the air, such as odious substances and NOx, and in the water, such as organic solvents and agricultural chemicals, without decomposing the fiber and plastic themselves, and to perform continuous decomposition and removal under irradiation of not just ultraviolet light, but also under visible light with a wavelength up to about 500nm.

Manufacturing Process

[0107] In the following, embodiments of various manufacturing processes for producing the photocatalysts of the present invention will be described.

Example 7

[0108] In this embodiment, an example of manufacturing a photocatalytic article is shown in which a Ti-O-N thin film photocatalytic thin film is prepared on a quartz substrate by sputtering.

[0109] A quartz substrate and a titanium oxide target are set in a vacuum chamber of a sputtering device. Then, a predetermined amount of nitrogen and argon gases (for example, Ar gas, Ne gas) is introduced into the vacuum chamber and sputtering is conducted in this mixed gas plasma. As a result, a Ti-O-N film with a thickness of 10 μ m or less is deposited on the quartz substrate.

[0110] The final vacuum before a sputtering gas was introduced was 2×10^{-5} Pa (1.5×10^{-7} Torr). This value is an important factor when preparing the photocatalysts of the present invention in a vacuum. Comparison of visible light operation performance after depositing film at the back pressures of 9×10^{-5} Pa and 4×10^{-4} Pa revealed that the lower the background vacuum pressure, the greater the decrease in the Ti-N binding amount and in the activity under visible light.

[0111] During sputtering, the whole pressure maybe set at, for example, 0.52 Pa and nitrogen partial pressure may be set in the range of $0\% < N_2$ partial pressure $\leq 100\%$, but the range of 20 to 60% is preferable. In addition, after depositing Ti-O-N film 12 by sputtering, heat treatment (annealing) is performed for crystallization. For example, crystallization can be conducted by heat treatment in a nitrogen atmosphere at 550°C for about two hours. That is, although simple film deposition yields an amorphous structure containing polycrystals, it is possible to use heat treatment to attempt poly- and single- crystallization. In addition, although heat treatment after depositing film may also be omitted by forming Ti-O-N film with heating the quartz substrate, performance of the final film is inferior compared to films which are annealed after depositing

[0112] By forming Ti-O-N film by the above method, Ti-O-N photocatalytic film can be formed by substituting nitrogen atom N for some of the oxygen sites of titanium oxide crystals.

[0113] In an experimental example, the nitrogen content in atomic percent in Ti-O-N film was 6.6% before heat treatment and 1.4% after heat treatment for film deposition by N_2 partial pressure 20% and 12.7% before heat treatment and 0.5% after heat treatment for film deposition by N_2 partial pressure 100%. In addition, for film deposition by N_2 partial pressure 40% and 60%, nitrogen contents after heat treatment were 1.4% and 1.5%, respectively.

[0114] Here, the state of nitrogen atom forming Ti-O-N photocatalysts manufactured by the method of this embodiment will be described in comparison with conventional titanium oxide powders. In the determination by X-ray diffraction, diffraction lines of anatase and rutile type titanium oxides were observed, but no diffraction lines derived from titanium nitride (TiN and Ti_2N) were observed. In addition, judging the chemical bonding state of nitrogen atoms from the determination results of the 1s shell of nitrogen N by XPS (X-ray Photoemission Spectroscopy) using a Mg-K α X-ray, as shown in Fig. 6, nitrogen atoms in Ti-O-N of this embodiment show a peak derived from Ti-N bonding near 396 to 397 eV. It can be understood from these results that nitrogen atoms are substituted for oxygen atoms of titanium oxide.

[0115] As described above, the two determination results of X-ray diffraction and XPS of the Ti-O-N photocatalysts of the present invention demonstrated that in Ti-O-N having anatase + rutile crystalline structure there is chemical bonding between Ti and N atoms.

[0116] As can be found in a powder and a film which are marketed as titanium oxide for photocatalysts, nitrogen atoms may generally be incorporated during a manufacturing process, but, as shown in Fig. 6, the peak of these nitrogen atoms appears near 400 eV. In other words, because nitrogen atoms incorporated in conventional titanium oxides form an organic compound and a nitro group, no Ti-N bonds are observed. Thus, the chemical properties of N in these substances, whether incorporated during the manufacturing process or modified on the surface by post-treatment, differ from those of the present invention.

[0117] Moreover, for $Ti_{33.9}O_{64.7}N_{1.4}$ with a film thickness 160 nm produced according to Embodiment 7, the determination results of a photocatalytic activity are marked in \bigcirc in Fig. 14(b). This determination was conducted by determining the methylene blue decomposition rate from light transmission by substituting a visible light source with a wavelength $\lambda \geq 410$ nm having spectra shown in Fig. 14(a) for a light source of a photocatalytic checker (manufactured by SINKU-RIKO INC.).

[0118] It is found that for the sputtering method according to Embodiment 7, the photocatalytic activity at a wavelength $\lambda \geq 410$ nm is markedly improved as compared to anatase type titanium oxide (expressed as a black rhombus in Fig. 14(b)) manufactured by the same method.

[0119] A photocatalytic function was exhibited in all Ti-O-N films manufactured at nitrogen gas partial pressure of 20, 40, 60, and 100%. For example, in a film of a composition ratio $Ti_{32}O_{66}N_2$, similar photocatalytic activity was shown. Therefore, it was found that the nitrogen content of Ti-O-N film may be $0 < X < 13$ if its content in atomic % is X%. In addition, as the photocatalytic function of Ti-O-N film, that after heat treatment is superior and, as the nitrogen concentration after heat treatment, 5% or less is preferable.

[0120] Effects of ammonium salt observed by XPS at the outermost surface of the sample described above will next be described. In the embodiment in Fig. 6, a peak derived from a Ti-N bond is observed near 397 eV. In the visible light operation type photocatalysts of the present invention, a comparison between presence and absence of peak near 402 eV indicates that an activity is higher in the presence. This peak is considered to be that derived from ammonium salt and differs in bond energy from that derived from a nitro group ($-NO_2$) in conventional art.

[0121] Although Ti-O-N film was deposited above using a titanium oxide target in plasma of argon gas containing nitrogen gas, a titanium nitride target may be deposited in plasma of gas containing oxygen. In addition, as a target, titanium oxide and titanium nitride may be used, and a mixture target of titanium oxide and titanium nitride can also be used.

[0122] Moreover, as a substrate, in addition to those described above, various substances such as glass, ceramic,

metal, and organic substances such as activated carbon, a plate of materials such as silica, alumina, and fluororesin, and a porous body of honeycomb structure can be utilized.

Example 8

[0123] Titanium oxide (III) (Ti_2O_3) is evaporated on a glass substrate by electron beam evaporation. Then, nitrogen gas is introduced into a vacuum chamber so that the whole pressure is 0.0266Pa (0.2mTorr). By heat treating a manufactured film in a 100% nitrogen gas atmosphere at 500°C for two hours, Ti-O-N film of anatase + rutile structure is manufactured. XPS analysis of this film confirmed a bond between Ti and N atoms and the results of X-ray diffraction demonstrated neither TiN nor Ti_2N crystals. TiO-N photocatalysts formed have either one or a combination of nitrogen atoms substituted for some oxygen sites of titanium oxide crystals, doped at interstitial sites of lattices of a titanium oxide crystal, and doped to grain boundaries of titanium oxide.

[0124] Furthermore, evaporating materials may be not only titanium oxide (III) as described above, but also titanium oxide and metal titanium of different composition ratios. In addition, as a substrate, in addition to that described above, various substances such as glass, ceramic, metal, and organic substances such as activated carbon, a plate of materials such as silica and a porous body of honeycomb structure can be utilized.

[0125] Moreover, the atmosphere at evaporation may be a mixed atmosphere of nitrogen and oxygen gases. In such a case, because the higher the oxygen gas partial pressure, the more difficult for nitrogen atoms to enter a film, the nitrogen composition ratio in the film becomes lower. Therefore, heat treatment with ammonia gas is effective. Treatment temperature at that time may be in the temperature range between 400 and 700°C. Treatment at temperatures exceeding this range is undesirable because titanium nitride is formed. In addition, Ti-O-N photocatalytic film with high adhesion to a base material may be formed by using the ion plating method in which a plasma state is made in a vacuum atmosphere at evaporation and in which evaporated grains are ionized and activated as excited grains, the arc ion plating method, and electron beam excited plasma. In addition, also by the cluster ion beam method, it can be manufactured by selecting a condition.

[0126] Moreover, by depositing in an oxygen atmosphere, a titanium oxide film is formed. When this is heat treated in an atmosphere containing ammonia gas or both nitrogen and hydrogen in the temperature range from 400 to 700°C a Ti-O-N photocatalyst is produced.

Example 9

[0127] In this embodiment, an example of manufacturing by a sol gel method using alkoxide will be described. A titania sol is prepared by suspending titanium oxide of an ultra fine grain in water and by hydrolyzing alkoxide of titanium obtained by the reaction of alcohol with titanium tetrachloride and metal titanium. Then, addition of alcohol amines such as monoethanolamine and diethanolamine, triethanolamine, N-methyldiethanolamine, N-ethyl diethanolamine, N, N-dimethyldiaminoethanol, and diisopropanolamine, and glycols such as diethylglycol produces a uniform transparent titania sol.

[0128] Ti-O-N photocatalytic film exhibiting a photocatalytic activity not only under irradiation of ultraviolet light, but also under visible light can be manufactured by coating these titania sols by dropping, application, and spray methods and by heat treating in an atmosphere containing ammonia or nitrogen. Preferable treatment temperatures are in the range from 300 to 800°C. and more preferably between 450 and 700°C.

Example 10

[0129] In this embodiment, a method of coating the surface of a carrier with Ti-O-N by treating in a gas will be shown. By immersing a honeycomb structure body in a solution in which a titanium oxide grain is dispersed and suspended, the surface of the structure body is coated with the above titanium oxide dispersion solution. By then heat treating the structure in an atmosphere containing ammonia gas or nitrogen at 550°C, the solution portion is evaporated, and Ti-O-N is formed on the surface of the honeycomb structure body. Heat treatment temperatures may be within a range between, for example, 450°C and 700°C.

[0130] Moreover, in the case that a mixed gas of ammonia gas and an inert gas such as argon gas is used as a reaction gas, the temperature range for forming the Ti-O-N phase of the present invention without forming titanium nitride can be broadened, and reproducibility of manufacture can be improved. In addition, gas handling is simplified and made more convenient. Still further, by subjecting the structure to preliminary heat treatment before subsequent heat treatment in an atmosphere containing ammonia gas or nitrogen, adhesion of the honeycomb structure body to a photocatalytic grain is improved.

[0131] Fig. 15 shows the light transmission spectra for Ti-O-N in a film form manufactured on a glass plate by heat treating as described in a mixed gas (nitrogen + argon) atmosphere. Because visible light transmission decreases as

treatment time is lengthened from 30 to 60 minutes, it can be judged that visible light absorbing performance is improved by heat treatment in an ammonia atmosphere.

[0132] Fig. 16 shows analysis results by XPS for tests performed on films prepared as described above. Peaks derived from a Ti-N bond are observed near 396 to 397eV. Because no diffraction line derived from titanium nitride (TiN) crystals is observed in X-ray diffraction, it was found that a photocatalytic substance is formed in which nitrogen is contained in titanium oxide crystals by substituting nitrogen atoms for some of the oxygen sites of titanium oxide crystals with the treatment of this embodiment.

[0133] Moreover, the composition ratio analyzed by XPS was $Ti_{34}O_{65}N_1$ in all treatment conditions.

[0134] Here, a sol for coating the surface of the honeycomb structure body with Ti-O-N may be titanium alkoxide usually employed for forming a titania film. A solution of titanium chloride and organic titanium compound may also be employed. In addition, an aqueous solution in which hydrochloric acid and ethanol are dissolved is mixed in a solution of titanium isopropoxide in ethanol. When this mixed solution is stirred at a temperature of 40 to 50°C, a sol is formed, which may be employed.

[0135] Furthermore, Ti-O-N photocatalyst may be formed using a glass fiber, zeolite, a FSM porous body, activated carbon, a fiber or the like instead of the honeycomb structure body.

Example 11

[0136] Titanium oxide grains with a grain diameter of about 10nm are set in a chamber, which is evacuated to below 1.33×10^{-3} Pa (1×10^{-5} Torr). Subsequently, nitrogen gas, for example 0.399Pa (3mTorr), is introduced into the chamber and high frequency plasma is produced with 200 W electric power. Ti-O-N photocatalyst can be manufactured by conducting this high frequency nitrogen plasma irradiation for 30 minutes. In addition, a gas producing plasma may not be limited to nitrogen gas and the use of a mixed gas nitrogen gas and an inert gas or that of nitrogen gas and hydrogen gas further improves the effect. The electric power employed during manufacture is not limited to a 200 W power, and would, in fact, normally vary according to device size. In addition, the above titanium oxide may be in the form of a film or fiber instead of a grain. Low temperature plasma such as ECR plasma or heat plasma of any nature may also be employed as the plasma, which can also be realized by techniques such as microwave plasma CVD. However, photocatalytic performance is inferior when plasma treatment is performed at room temperature.

Example 12

[0137] This embodiment illustrates a manufacturing example by ion-implantation. More specifically, using an ion implantation device, nitrogen ions are accelerated to energy between 30keV and 500keV and applied to titanium oxide. Here, it is desirable that most implanted nitrogen ions be distributed from the surface of titanium oxide to the depth of about 300Å from the surface. As implantation energy, between 50keV and 400keV is preferable, and between 100 keV and 200 keV is more preferable.

[0138] The ion implantation device which may be employed is not uniquely limited. A commercial device employed for doping impurities in a semiconductor field may be used. However, a device in which implantation energy and amount can be set to desired values is preferable.

[0139] It is desirable that implantation amounts of ions implanted in titanium oxide are between 1×10^{14} and 1×10^{19} ions per 1cm^2 of irradiation area, with amounts between 1×10^{16} and 1×10^{17} being especially preferable. If the introduction amount of an ion is too little, the effect of exhibiting a photocatalytic activity by absorbing light in the visible light region is lowered. Conversely, if the introduction amount of an ion is too great, an activity can be undesirably reduced.

[0140] It is desirable that Ti-O-N after ion implantation is treated by annealing. By performing annealing treatment, a photocatalytic activity is further improved. The method of annealing treatment is not specially limited. Generally, annealing is performed using an electric furnace in the air. The temperature of annealing treatment is usually 200°C or more and 700°C or less, preferably 300°C or more and 500°C or less. The time for annealing treatment is also not especially limited and can be selected as appropriate, with one to six hours being commonly chosen periods.

Example 13

[0141] This embodiment illustrates an example of preparation of an ultra fine grain photocatalyst Ti-O-N film. A manufacturing device is shown in Fig. 17. This device comprises an ultra fine grain producing chamber 10, a differential exhaust chamber 12, and a film forming chamber 14, wherein the ultra fine grain producing chamber 10 is connected by a tube 16 to the differential exhaust chamber 12 and the differential exhaust chamber 12 is connected by a tube 18 having a valve 20 to the film forming chamber 14. In addition, a vacuum pump 22 is connected through each valve to the ultra fine grain producing chamber 10, the differential exhaust chamber 12, and the film forming chamber 14.

Further, the ultra fine grain producing chamber 10 is provided with a composite EC boat 24 in which resistance heating is possible and in addition, is so designed that helium gas and a nitrogen + oxygen mixed gas may be introduced into it. In addition, the film forming chamber 14 is provided with a depositing base 26.

[0142] First, the ultra fine grain producing chamber 10, the differential exhaust chamber 12, and the film forming chamber 14 are all evacuated to about 10^{-4} Pa (10^{-6} Torr). Thereafter, He gas is introduced into the ultra fine grain producing chamber 10 to the extent of 13.3 kPa (100 Torr). Then, through a nitrogen gas exhaust nozzle within the ultra fine grain producing chamber 10, a predetermined flow of a nitrogen + oxygen mixed gas begins to flow. Subsequently, an electric current is applied to the composite EC boat 24 and is so controlled that metal titanium on the boat 24 reaches a predetermined evaporation temperature. Evaporated Ti reacts with oxygen as well as nitrogen to form Ti-O-N. The flow ratio of reaction gas at this time is nitrogen : oxygen = 99.99 : 0.01 to 90 : 10.

[0143] When grains are being deposited, by opening the valve 20 for flow from the differential exhaust chamber 12 to the film forming chamber 14, gas mixed with Ti-O-N grains is run into the ultra fine grain producing chamber 10 at a flow of He gas 200 ml/min. In the film forming chamber 14, glass, ceramic, metal, and organic substances such as activated carbon, a plate of materials such as silica, and a porous body of honeycomb structure are mounted on the depositing base 26 and by moving this depositing base 26 at a predetermined rate, gas mixed with ultra fine grain is sprayed to form an ultra fine grain film.

[0144] Moreover, although metal titanium is described as an evaporation material, titanium nitride and oxide may also be used for an evaporation material.

[0145] Furthermore, the photocatalyst grains of the present invention can also be manufactured by other methods including physical techniques such as metallic vapor synthetic and fluidized bed vacuum evaporation methods, chemical methods in the liquid phase such as colloid and alkoxide methods, and chemical methods in the gaseous phase such as a heat decomposition method of organic metal compounds and a method of reducing titanium chloride, oxide and hydrous oxide, acid nitride, and nitride in gas containing ammonia or nitrogen.

Example 14

[0146] This embodiment shows a method of manufacturing a Ti-O-N photocatalytic powder with a large specific surface area using an emulsion combustion method. The manufacturing method of the present invention comprises spraying either one or both of emulsions in which substances containing titanium or both titanium and nitrogen atoms, or a suspension in which both substances containing titanium and those containing nitrogen atoms are suspended in a flammable liquid, or an emulsion in which a solution of the above substance is emulsified in a flammable liquid and heating said suspension or emulsion in an atmosphere of one or more of nitrogen and ammonia gas.

[0147] These substances may be a metal, a metal salt, or the like, including chlorides and complex salts of titanium or the like. That is, substances containing titanium atom with which the above suspension and emulsion may be prepared may be used as a raw material regardless of their form. In addition, titanium alkoxide may be used.

[0148] Moreover, a suspension may be prepared by suspending substances containing titanium or both titanium and nitrogen atoms or both substances containing titanium and those containing nitrogen atoms in a flammable liquid. An emulsion may be prepared by emulsifying in a flammable liquid substances containing titanium or both titanium and nitrogen atoms or a solution of both substances containing titanium and those containing nitrogen atoms in a solvent. Thus, even substances which are not always soluble in a solvent can be used as a raw material for manufacturing a photocatalytic powder by suspension in a flammable liquid.

[0149] Furthermore, for a suspension, as a form of a substance suspended in a flammable liquid, many forms, such as a grain form may be employed, but the finer the form, the finer will be the obtained powder. In addition, for an emulsion, as a solvent for dissolving substances containing titanium or both titanium and nitrogen atoms or both those containing titanium and those containing nitrogen atoms, water is desirable.

[0150] Flammable liquids which may be used as a medium for suspension or emulsion include, alone or in combination, kerosene, gasoline or the like.

[0151] Because mixing is performed in a liquid state when preparing a suspension or an emulsion, said suspension or emulsion is homogenous and, because no temperature distribution occurs because of this homogeneity when a nitrogen oxide is manufactured and when a suspension or an emulsion is sprayed and heated, the homogeneity of composition is not impaired.

[0152] Moreover, when emulsifying in a flammable liquid substances containing titanium or both titanium and nitrogen atoms or a solution of substances containing titanium and substances containing nitrogen atoms, addition of an emulsifier or stirring with a homomixer or the like is preferable. Emulsifiers containing no metal ion are preferable, and, in particular, nonionic surface active agents are preferable.

[0153] By employing an appropriate emulsifier when preparing an emulsion, a suspension in which spherical particles with an approximately homogenous diameter are dispersed is obtained. The homogeneity of the diameter of this dispersion particle is reflected in the grain diameter of the resulting photocatalytic powder. Because preparation of an

emulsion with a homogenous dispersion particle diameter is a relatively simple task, an oxide powder composed of particles with a homogenous grain diameter can be readily manufactured. Production of an oxide powder with a more homogenous grain diameter is further simplified because there is no coagulation of sprayed grains.

[0154] Employable methods of spraying a suspension or an emulsion include spraying a suspension using a compressed air sprayer or spraying an emulsion using a quantitative pump or the like. Generally, increasing spray capacity will improve production efficiency, but, because a combustion temperature may become too high, there may be an upper limit to spray capacity.

[0155] In the present embodiment, a suspension or an emulsion is sprayed and said suspension or emulsion is heated in an atmosphere of either one or a combination of nitrogen and ammonia gas. A flammable liquid in a suspension or an emulsion is thereby combusted.

[0156] In heating methods, spray liquid drops are heated with a burner or the like or are passed through a flame or a substance heated to a high temperature. As an atmosphere when heating, either one or a combination of nitrogen and ammonia gas is necessary.

[0157] Manufactured photocatalytic powder is collected so that it does not scatter. In this way, a powder is manufactured. Because of the absence of conventional calcining and crushing processes, the method according to this embodiment enables the present invention to be performed in few processes without mixed impurities.

[0158] In an experimental test of the method of this embodiment, when as an initial material, TiCl_4 and NH_4Cl were used as Ti and N sources, respectively, the N composition ratio in the Ti-O-N photocatalyst was 4.5% and, after heat treating at 500°C in an air atmosphere later, the N composition ratio was 2.1%. When heat treating was performed at 800°C in air, the N composition ratio was 1.4%. Although the crystalline phase of two of the former is anatase and that of the latter was rutile, all exhibited a photocatalytic activity in the visible light region.

[0159] In a further test using, as an initial material, TiCl_4 as a Ti source in which ammonia gas was introduced instead of soaking NH_4^+ ions in liquid as a N source, a photocatalytic article was obtained in which the N composition ratio in Ti-O-N catalyst was 0.9%.

Example 15

[0160] Methods of hydrolyzing titanium compounds such as titanil sulfate, titanium sulfate, titanium chloride, and organic titanium compounds in the presence, if required, of a crystalline seed by adding ammonium salt and aqueous ammonia solution; or neutralizing by adding ammonium salt and/or aqueous ammonia solution to titanium compounds such as titanil sulfate, titanium sulfate, titanium chloride, and organic titanium compounds in the presence of a crystalline seed; or conducting hydrothermal treatment of a titanium oxide suspension by adding ammonium salt and/or aqueous ammonia solution, are all known. For aqueous solutions, it may be preferable that said hydrolysis of titanium compounds be conducted at temperatures up to their boiling point.

[0161] Although the products obtained by said methods can be used as Ti-O-N catalyst, as needed, said products may be separated, washed, and then dried or calcined. Separation can be performed by the methods such as ordinary filtration and a gradient method. Although drying can be performed at a given temperature, temperatures of 100 to 200°C are suitable. For the calcination temperatures, temperatures of 200 to 500°C are suitable.

Example 16

[0162] As a method for producing the photocatalyst of the present invention, the oxidizing of titanium nitride or acid titanium nitride is also effective. Here, an example of oxidizing a titanium nitride powder in an oxygen atmosphere will be described.

[0163] A titanium nitride powder (made by KOJUNDO CHEMICAL, mean primary grain diameter 33nm) was placed in a silica tube and was heat treated at 400°C for 90 minutes in an oxygen atmosphere. As a result, a yellow sintered body was formed. A yellow fine powder was prepared by crushing this body in a mortar. From X-ray diffraction analysis of this powder strong (110), (101), (200), (111), (210), (211), and (220) diffraction lines of rutile type titanium oxide and a very weak TiN (200) diffraction line were observed. The mean primary grain diameter of rutile titanium oxide estimated from the half-value width of a (110) diffraction line was 42nm. In addition, XPS clarified that there was also a Ti-N chemical bond in the powder.

[0164] Fig. 18 shows the diffuse reflectance spectrum of the powder. The curve labeled mark 111 in the figure is the reflectance spectrum for the photocatalytic powder of this embodiment and that expressed as the mark 112 is the reflectance spectrum for rutile type titanium oxide with mean primary grain diameter 19nm. From this result it can be understood that the Ti-O-N of this embodiment, in which a light absorption edge is shifted to the longer wavelength side than in ordinary rutile type titanium oxide, absorbs visible light.

[0165] Using this powder, decomposition of an aqueous methylene blue solution when irradiated with visible light was performed. About 0.05g of the powder was added to about 5cc of an aqueous $10\mu\text{M}$ methylene blue solution and

this mixture was irradiated with visible light while stirring. The light source used was a 10W fluorescent tube (Matsushita Electric Works, Ltd. FL10N) to which an ultraviolet cut filter (Fuji Photo Film Co., Ltd., SC42) was attached so that visible light with a wavelength $\lambda \geq$ approximately 400nm was irradiated. The distance to the light source was 1 cm. Ultraviolet intensity was 0.0 μ W/cm² (the light-intensity meter made by Topcon, UVR-2 and UD-36 were used). After irradiation for 48 hours, the solution was decolorized to be transparent and nearly colorless.

[0166] This test showed that a Ti-O-N photocatalyst can be easily formed from a material having a Ti-N bond. In addition, by selecting treatment conditions, a photocatalytic article having the structure of Ti-O-N within a powder and titanium oxide on the outermost surface can be formed.

[0167] Using this method, also when treating at 550°C, a rutile type visible light catalyst powder was similarly obtained. In addition to this method, when an oxidation atmosphere is employed as a treatment atmosphere, similar effects may be obtained with any atmosphere such as atmospheres containing oxygen gas, ozone, water molecule, and a hydroxyl group, which all may be employed. In addition, the photocatalytic article of the present invention can be similarly prepared also by the emulsion combustion method in an oxidation atmosphere. With any of these methods, a photocatalytic article having the structure of Ti-O-N within a powder and titanium oxide on the outermost surface can be formed by appropriately selecting treatment conditions.

Performance of Photocatalysts

[0168] Fig. 14 (b) shows the decomposition performance of methylene blue when irradiated with visible light with a wavelength $\lambda \geq$ 410nm shown in Fig. 14 (a) for a photocatalytic article of film structure according to the above embodiment. Representative samples are from embodiments which can readily produce a film, and the experimental results for these are shown. Specifically, experimental results for a Ti-O-N film prepared by sputtering in the Embodiment 7 explained above, an evaporation film according to Embodiment 8, an ion plating film according to Embodiment 8, and an ammonia treated film of titanium oxide according to Embodiment 10 are expressed as \circ , \square , \blacksquare , and Δ in the figure, respectively. Additionally, as a comparative example, the characteristics of the titanium oxide film are also expressed as \diamond . It is clear from these results that the photocatalyst, and the manufacturing process, of the present invention realizes a photocatalyst exhibiting a high activity when irradiated with visible light, as well as ultraviolet light.

[0169] Fig. 19 shows experimental results when a photocatalytic thin film according to Embodiment 1 was evaluated under daylight fluorescent lighting. Light was irradiated from a position 15mm away from a fluorescent tube with brightness 2000cd/m². The photocatalyst of the present invention exhibited strong photocatalytic activity even under white fluorescent lighting. Because white fluorescent lighting has extremely low content of ultraviolet radiation compared with solar lighting, conventional titanium oxide photocatalysts do not exhibit photocatalytic performance in a normal indoor dwelling environment. In contrast, it is found that the photocatalysts of the present invention exhibit sufficient or superior effects even in such an indoor environment.

Modifications

[0170] Furthermore, for the Ti-O-N crystal system of the present invention, it is undesirable that titanium nitride TiN crystals be formed inside a material. The Ti-O-N with which the present invention is concerned, as described above, is obtainable by either one or a combination of doping nitrogen atoms at the interstitial sites of lattices of a titanium oxide crystal, doping nitrogen atoms to grain boundaries of titanium oxide, and, more preferably, substituting nitrogen atoms for some of the oxygen sites of titanium oxide crystals and consequently only diffraction lines of titanium oxide appear in the analysis by the X-ray diffraction method. In general, although for titanium oxide photocatalysts produced by conventional art, those of anatase type are desirable because of their high activity, for the photocatalysts of the present invention, any crystal systems of anatase, rutile, and brookite may be employed as their basic crystal.

[0171] Moreover, although for the processes in the above embodiments, Ti-O-N photocatalysts were used as illustrative examples, the subject of these processes is not limited to Ti-O-N, and they can also be applied to material systems in which at least one of S, B, C, P, Cl, As, Se, Br, Sb, Te, and I is further doped to Ti-O-N.

[0172] Furthermore, the photocatalysts of the present invention can also be used as a reduction catalyst. In addition, the photocatalysts can be also employed as catalysts for synthesizing other substances from a given raw material.

Industrial Applicability

[0173] The photocatalysts of the present invention react when exposed to visible light. Hence, it is possible to perform antifogging and organic substance removal by forming on the surface of various materials placed under a condition in which visible light is irradiated.

Claims

1. A photocatalytic material which exhibits a photocatalytic reaction when exposed to light with a wavelength in the region of visible light, said material comprising Ti-O-N in which nitrogen is present within titanium oxide crystal.
2. The photocatalytic material according to claim 1, wherein a nitrogen atom is present within the titanium oxide crystal by at least one of substituting a nitrogen atom for an oxygen site of titanium oxide crystal, doping a nitrogen atom at an interstitial site of lattices of titanium oxide crystal, or doping a nitrogen atom between grain boundaries of titanium oxide.
3. The photocatalytic material according to claim 1 or 2, wherein there exists a chemical bond between the nitrogen atom present in the titanium oxide crystal and a titanium atom.
4. The photocatalytic material according to any one of claims 1 to 3, wherein the nitrogen atom is substituted for an oxygen site of titanium oxide crystal.
5. The photocatalytic material according to any one of claims 1 to 3, wherein the N1s shell bond energy spectrum of the photocatalytic material exhibits at least one peak in the 400eV or less region when measured using X-ray photoemission spectroscopy.
6. The photocatalytic material according to any one of claims 1 to 3, wherein the N1s shell bond energy spectrum of the photocatalytic material exhibits at least one peak in the region between 396eV and 398eV when measured using X-ray photoemission spectroscopy.
7. The photocatalytic material according to any one of claims 1 to 3, wherein said photocatalytic material has an impurity level caused by substituting a nitrogen atom for an oxygen site of titanium oxide between the band gap of a valence band and a conduction band of titanium oxide.
8. The photocatalytic material according to any one of claims 1 to 7, wherein the nitrogen content X expressed in atomic % is $0 < X < 13\%$.
9. The photocatalytic material according to any one of claims 1 to 8, wherein the atomic % values Y, Z, and X for titanium, oxygen, and nitrogen satisfy the expression, $0.4 < Y/(X + Z) < 0.6$.
10. The photocatalytic material according to any one of claims 1 to 9, wherein the X-ray photoemission spectroscopy spectrum exhibits a peak derived from ammonium salt.
11. The photocatalytic material according to any one of claims 1 to 10, wherein the crystal face of a photocatalytic article or a film is mainly oriented along the C axis direction on its surface.
12. A photocatalyst according to any one of claims 1 to 11 comprising titanium oxide on the external surface of the photocatalytic material.
13. A photocatalyst comprising as an inner component at least one of titanium oxide, silica, alumina, fluororesin, or those containing nitrogen, and as an external component on the whole or some portion of the external surface the photocatalytic material according to any one of claims 1 to 11.
14. A photocatalyst wherein at least one of titanium oxide, silica, alumina, fluororesin or those containing nitrogen is mixed with the photocatalytic material according to any one of claims 1 to 11.
15. A photocatalyst wherein, on the surface of the photocatalyst according to any one of claims 1 to 14, ceramic with a lower photocatalytic activity than said photocatalyst is carried in an island, needle, or mesh form.
16. The photocatalytic article according to claim 15, wherein the ceramic with a lower photocatalytic activity than said photocatalyst is at least one selected from alumina, silica, zirconia, magnesia, calcia, calcium phosphate, amorphous titanium oxide, and fluororesin.
17. The photocatalytic article according to claim 15, wherein the ceramic with a lower photocatalytic activity than said

photocatalyst is at least one selected from alumina, silica, zirconia, magnesia, calcia, potassium phosphate, amorphous titanium oxide, and fluororesin which contains nitrogen.

- 5 18. A method of manufacturing a photocatalytic article, wherein a thin film of the photocatalytic material according to any one of claims 1 to 17 is formed on a substrate by sputtering at least one of titanium-oxynitride, titanium oxide, titanium nitride, and metal titanium used as a target material in an atmosphere containing nitrogen gas.
- 10 19. A method of manufacturing a photocatalytic article, wherein a thin film of the photocatalytic material according to any one of claims 1 to 17 is formed on a substrate by vaporizing or ion plating at least one of titanium-oxynitride, titanium oxide, titanium nitride, and metal titanium used as a target material in an atmosphere containing nitrogen gas.
- 15 20. A method of manufacturing a photocatalytic article, wherein a thin film of the photocatalytic material according to any one of claims 1 to 17 is formed on a substrate by heat-treating titanium oxide or hydrated titanium oxide in an atmosphere containing ammonia gas, nitrogen gas, or mixture of nitrogen and hydrogen gases.
- 20 21. A method of manufacturing a photocatalytic article, wherein a thin film of the photocatalytic material according to any one of claims 1 to 17 is formed on a substrate by heat-treating a titanium alkoxide solution in an atmosphere containing ammonia gas, nitrogen gas, or mixture of nitrogen and hydrogen gases.
- 25 22. A method of manufacturing a photocatalytic article, wherein a thin film of the photocatalytic material according to any one of claims 1 to 17 is formed on a substrate by treating titanium oxide in plasma containing nitrogen atom.
- 30 23. A method of manufacturing a photocatalytic material, wherein the photocatalytic material according to any one of claims 1 to 17 is manufactured by implanting nitrogen atom in titanium oxide by ion-implantation.
- 35 24. A method of manufacturing a photocatalytic article, wherein a thin film of the photocatalytic material according to any one of claims 1 to 17 is formed on a substrate by vacuum evaporating at least one of titanium-oxynitride, titanium oxide, titanium nitride, and metal titanium used as an evaporating material in an atmosphere containing nitrogen gas, and then transferring it to a different vacuum vessel using differential pressure.
- 40 25. An emulsion combustion method of manufacturing the photocatalytic material according to any one of claims 1 to 17 comprising spray combustion of emulsion in the atmosphere such that ions or molecules containing nitrogen elements other than nitrate ion are present in an aqueous solution or suspension of metallic salts which is an aqueous phase in an emulsion and that an amount of oxygen introduced into a reactor is less than that required for producing the oxides of metallic ions or metal compounds which are in most stable forms in the air, keeping the sufficient amount of oxygen to burn the oil and surfactant completely.
- 45 26. A method of manufacturing the photocatalytic material according to any one of claims 1 to 17 comprising, in the emulsion combustion method, spray combustion of emulsion in the atmosphere in which nitrogen containing gas, except nitrogen gas, such as ammonia are contained in an aqueous solution or suspension of metallic salts which is the aqueous phase in an emulsion and in which the amount of oxygen introduced into a reactor is less than that required for complete oxidation.
- 50 27. A method of manufacturing the photocatalytic material according to any one of claims 1 to 17, wherein titanium oxide and titanium nitride are mixed and the mixture is heat-treated at a temperature between 400 and 700°C.
- 55 28. A method of manufacturing the photocatalytic material according to any one of claims 1 to 17, wherein titanium nitride or titanium-oxynitride is heat-treated or plasma-treated in an oxidation atmosphere containing oxygen, ozone, a water molecule, or a hydroxyl group.

Fig. 1

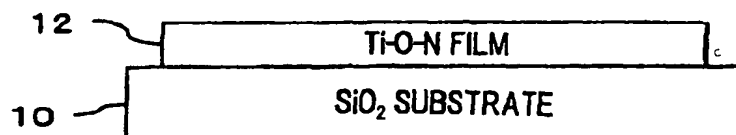


Fig. 2 (b)

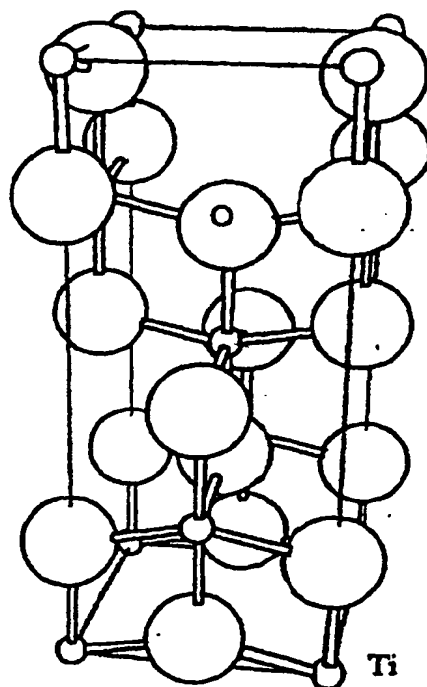


Fig. 2 (a)

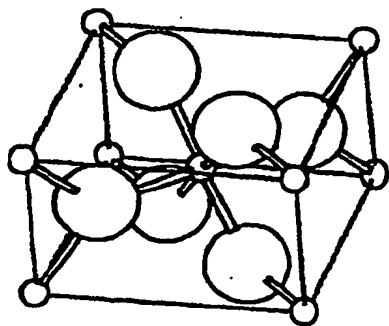


Fig. 3 (a)

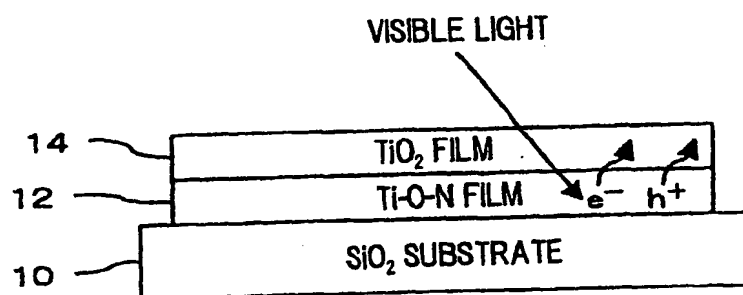


Fig. 3 (b)

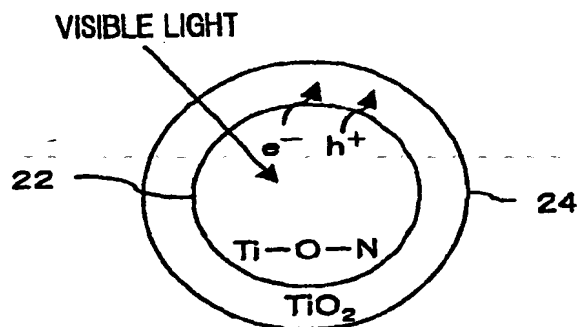


Fig. 4 (a)

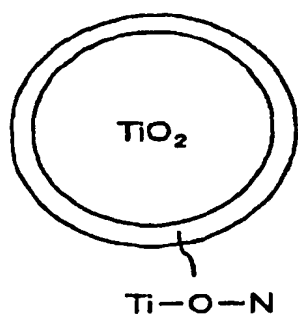


Fig. 4 (b)

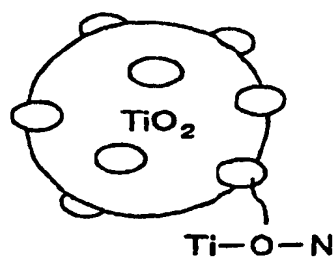


Fig. 5 (a)

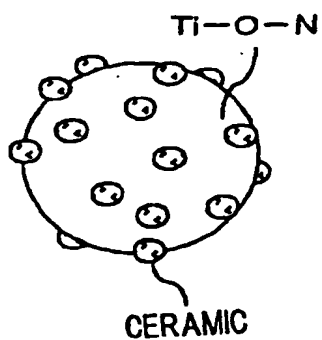


Fig. 5 (b)

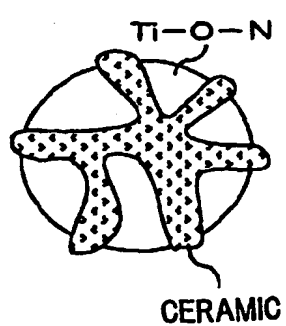


Fig. 5 (c)

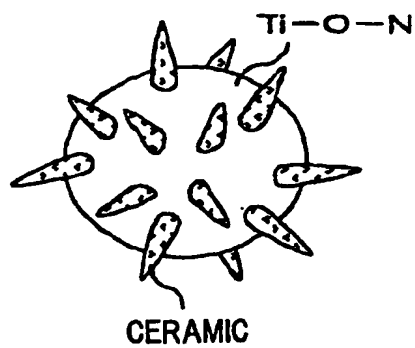


Fig. 6

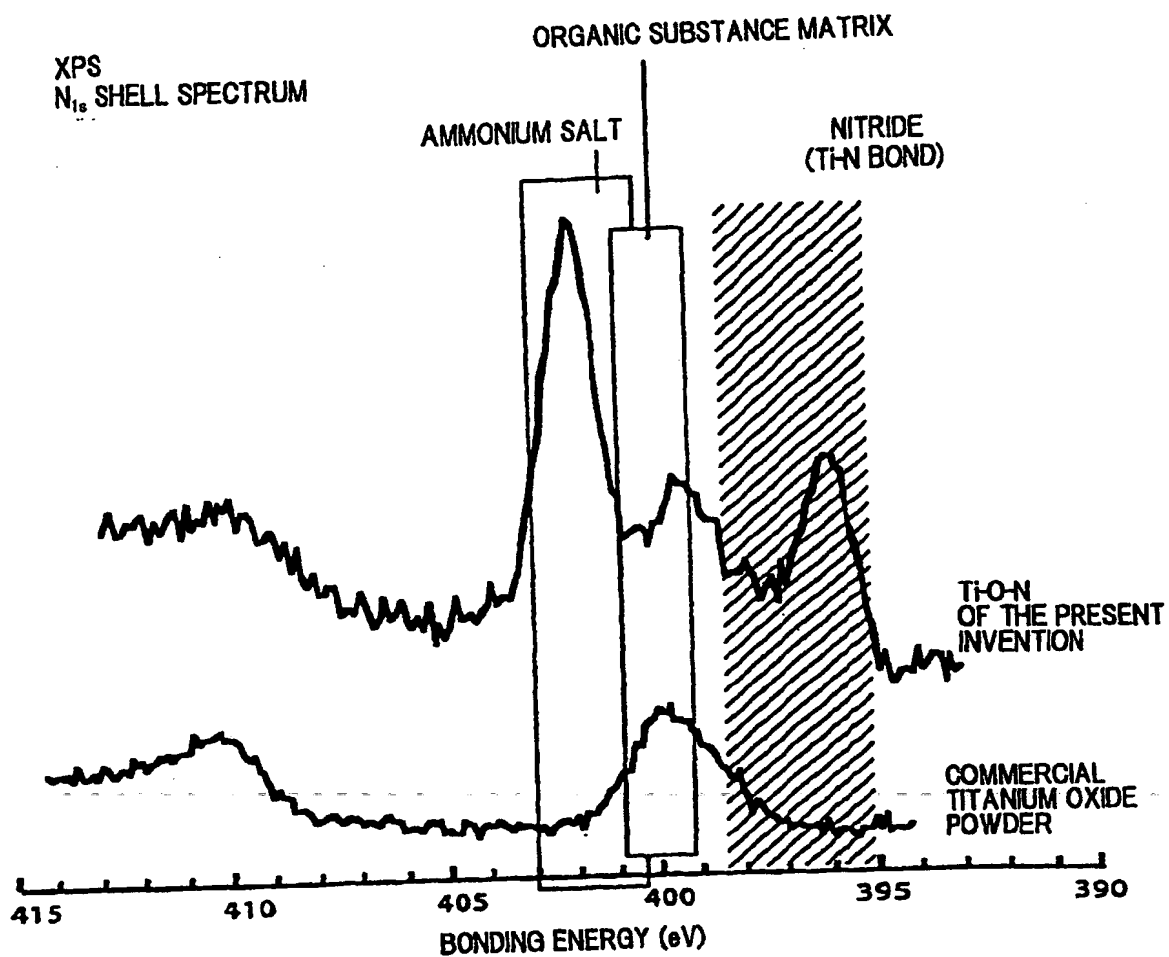


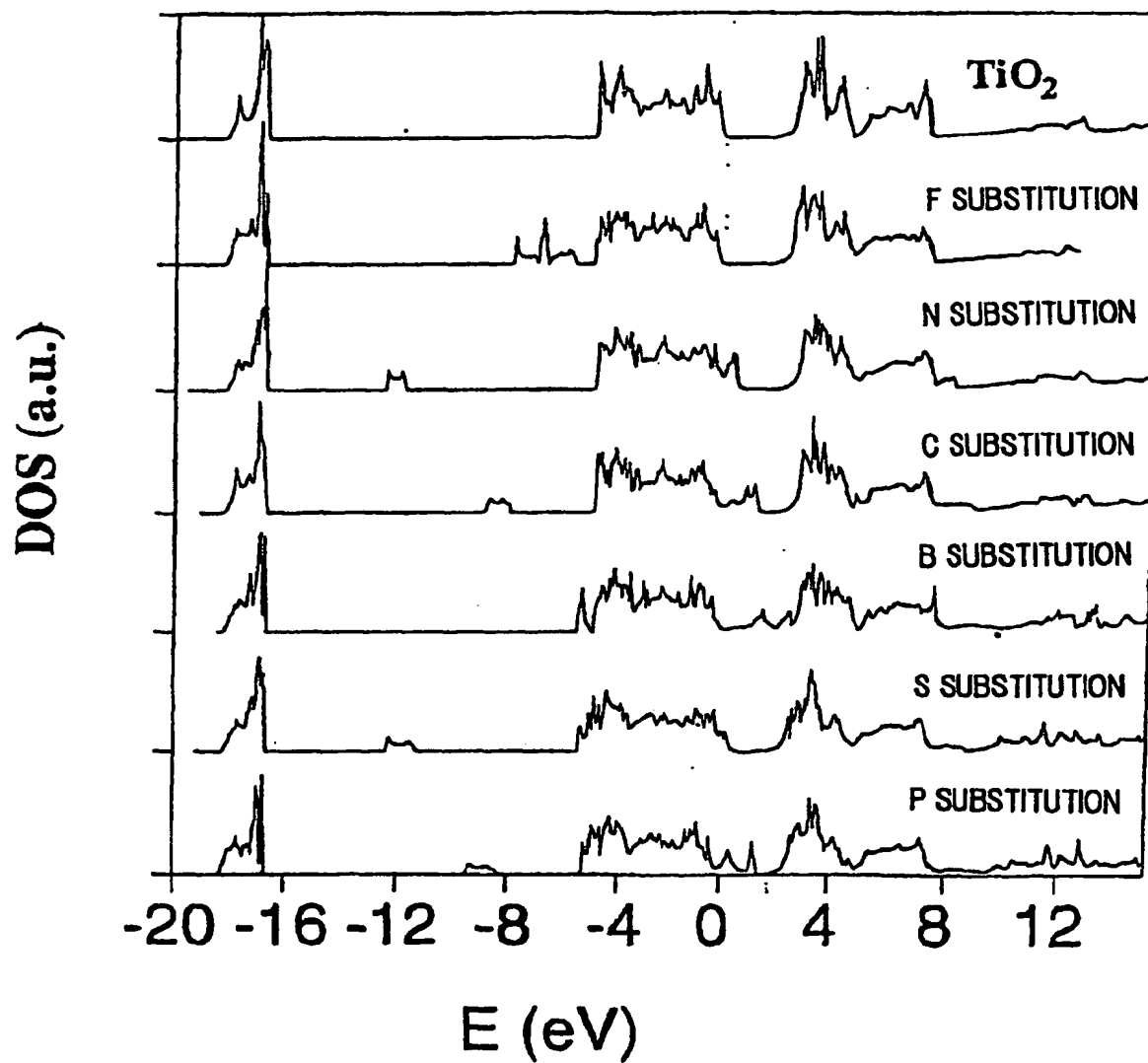
Fig. 7

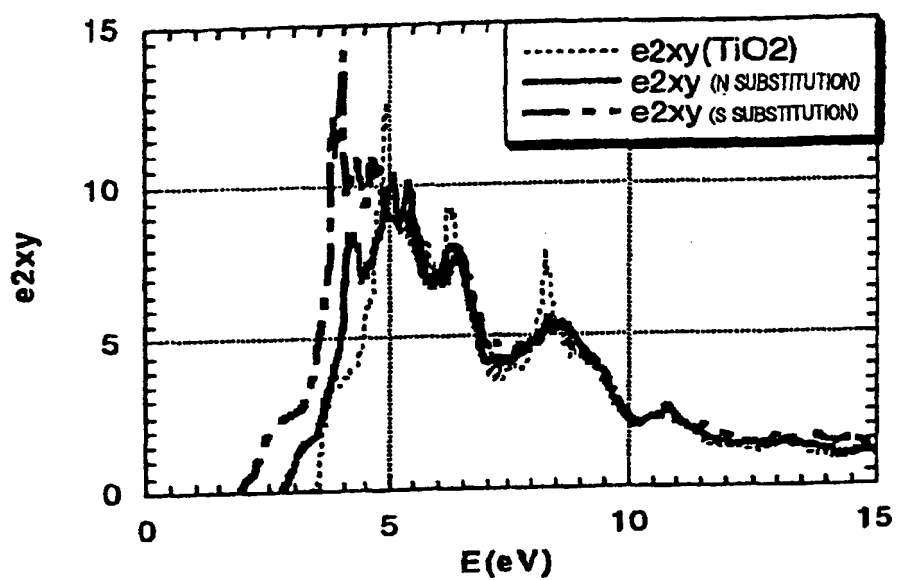
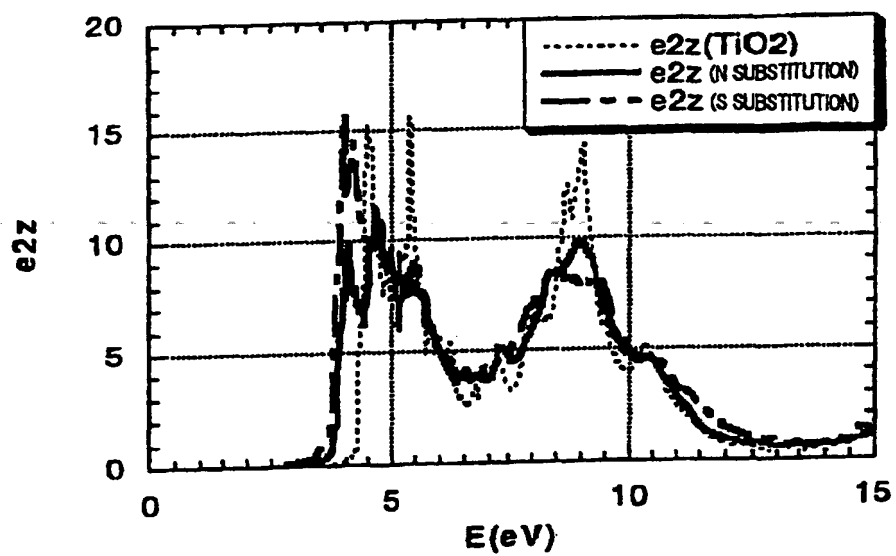
Fig. 8 (a)**Fig. 8 (b)**

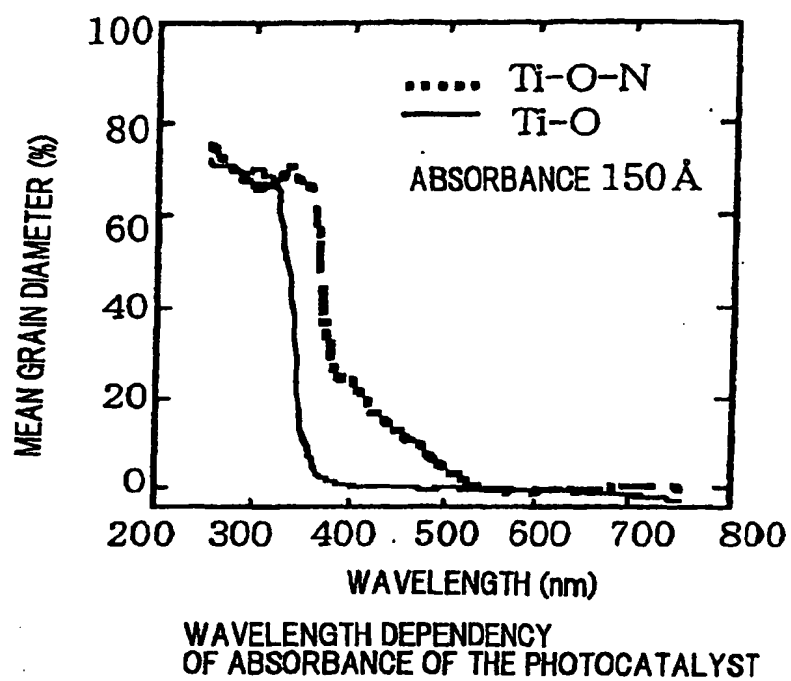
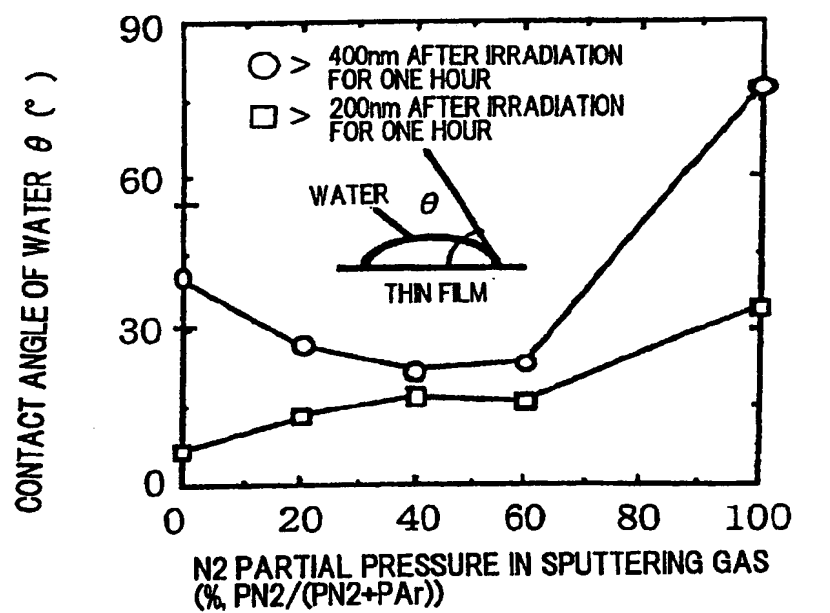
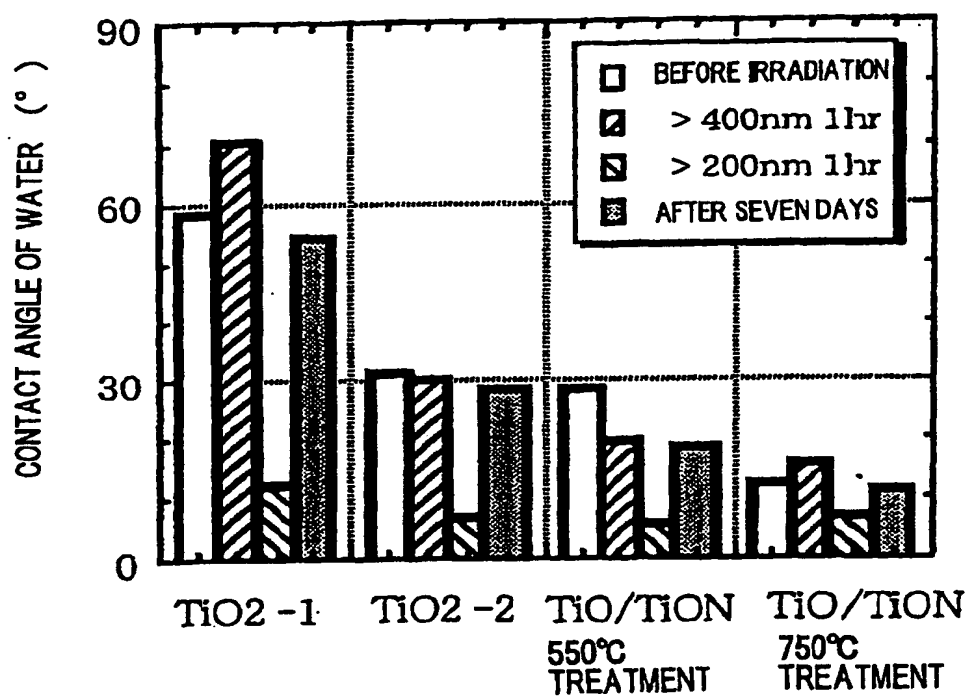
Fig. 9

Fig. 10

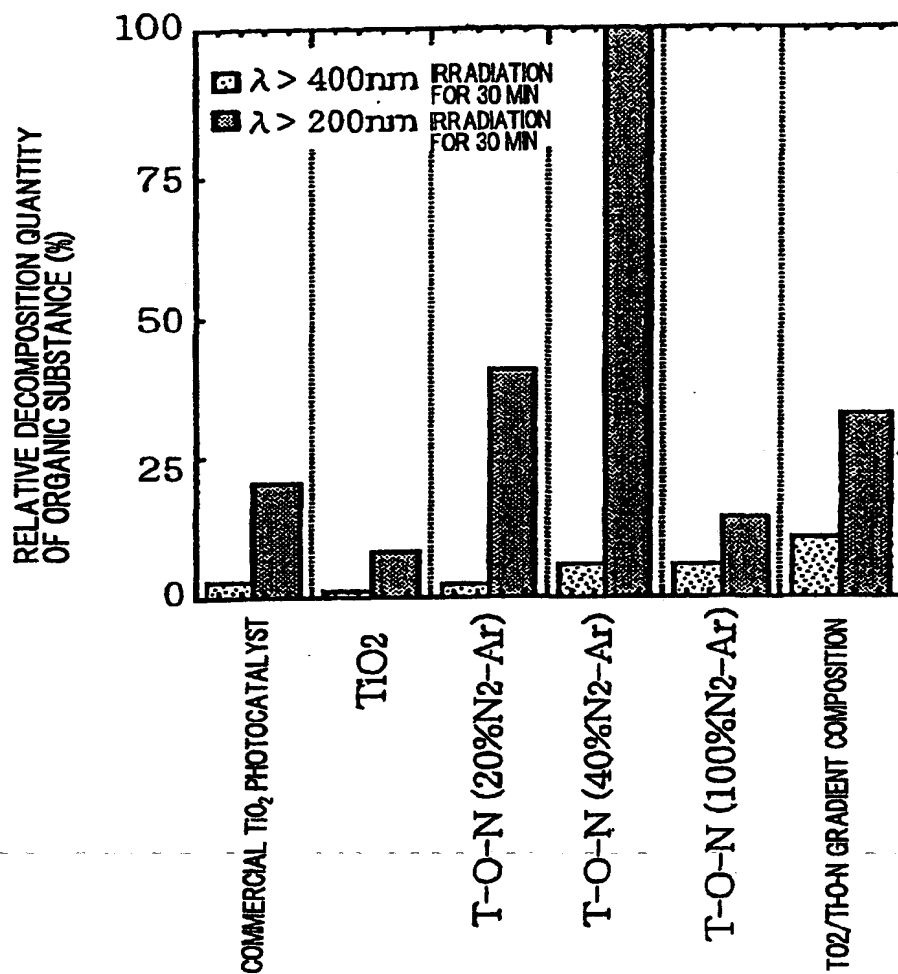


CONTACT ANGLE OF WATER AT THE FILM SURFACE

Fig. 11



CHARACTERISTICS OF LAMINATED TYPE PHOTOCATALYST

Fig. 12

COMPARISON OF DECOMPOSITION PERFORMANCE
OF ORGANIC SUBSTANCE ON THE PHOTOCATALYST

Fig. 13 (a)

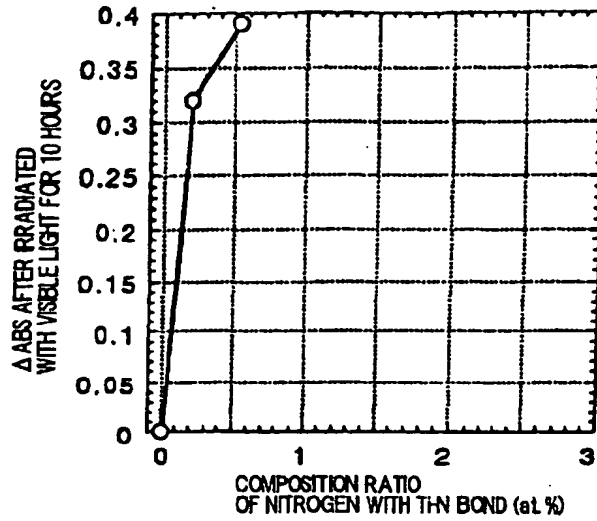


Fig. 13 (b)

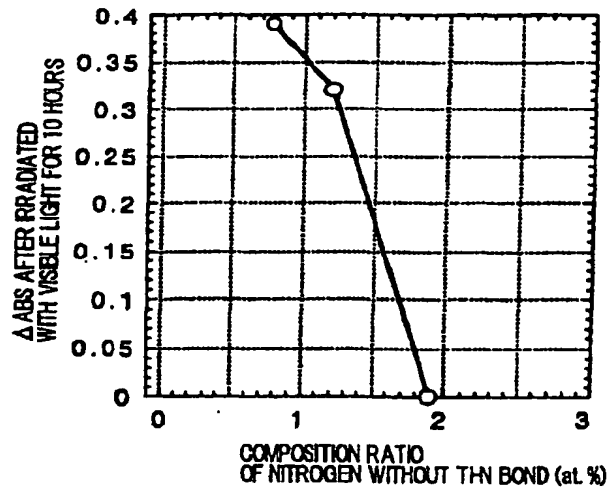


Fig. 13 (c)

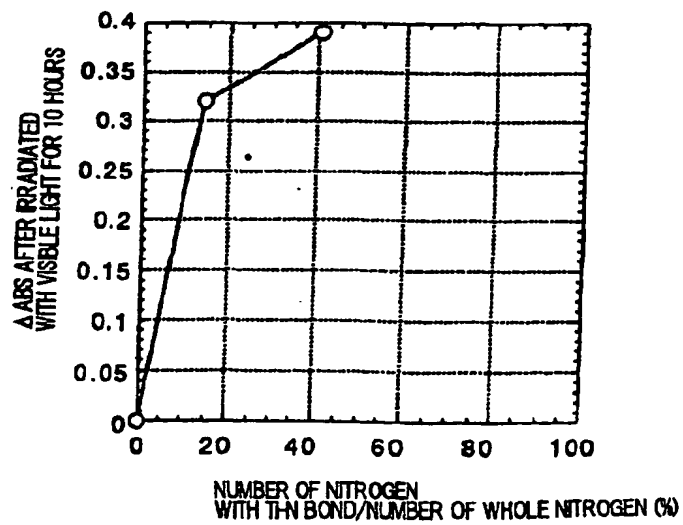


Fig. 14 (a)

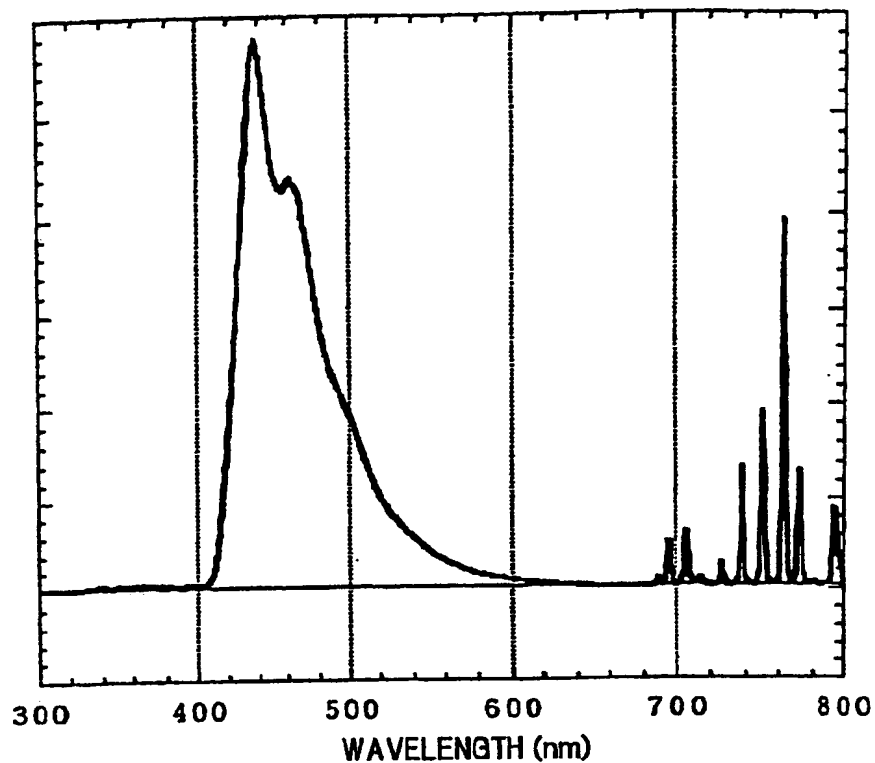


Fig. 14 (b)

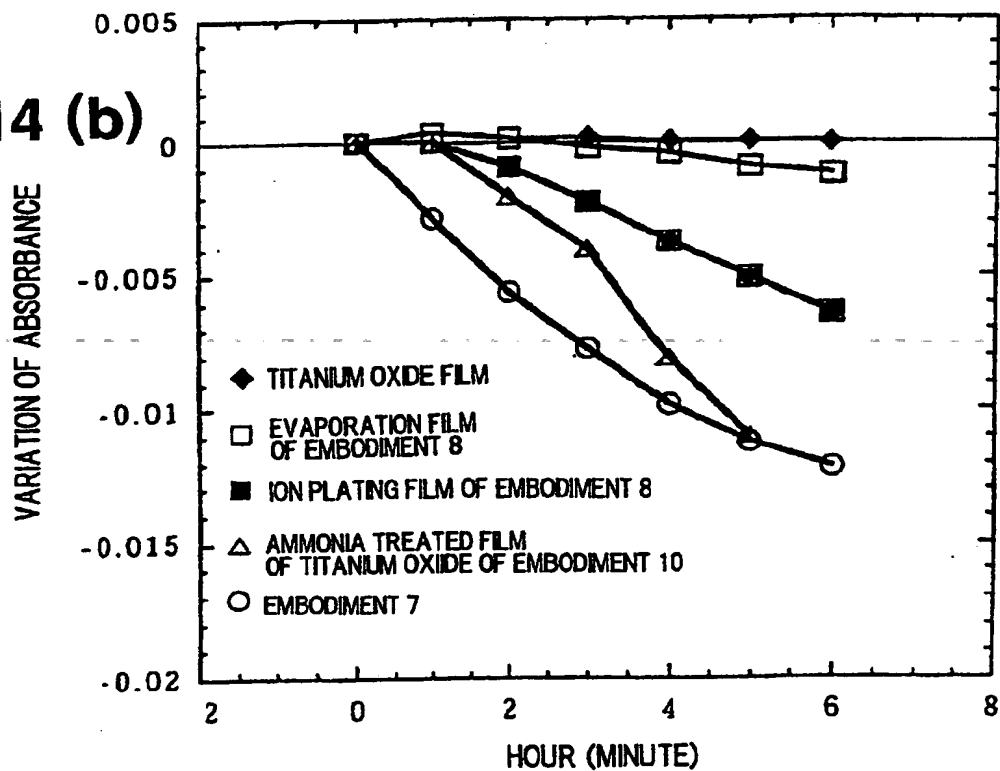


Fig. 15

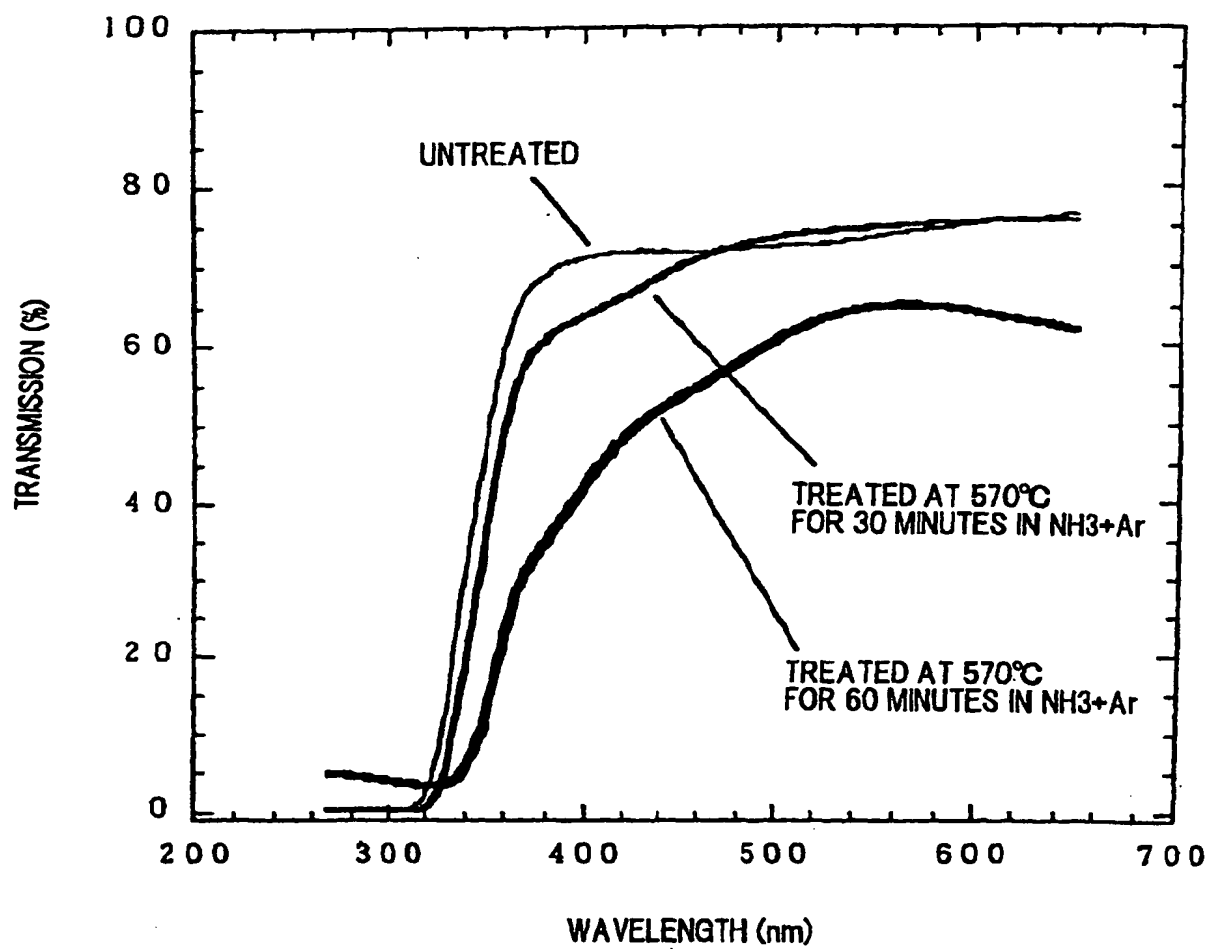


Fig. 16

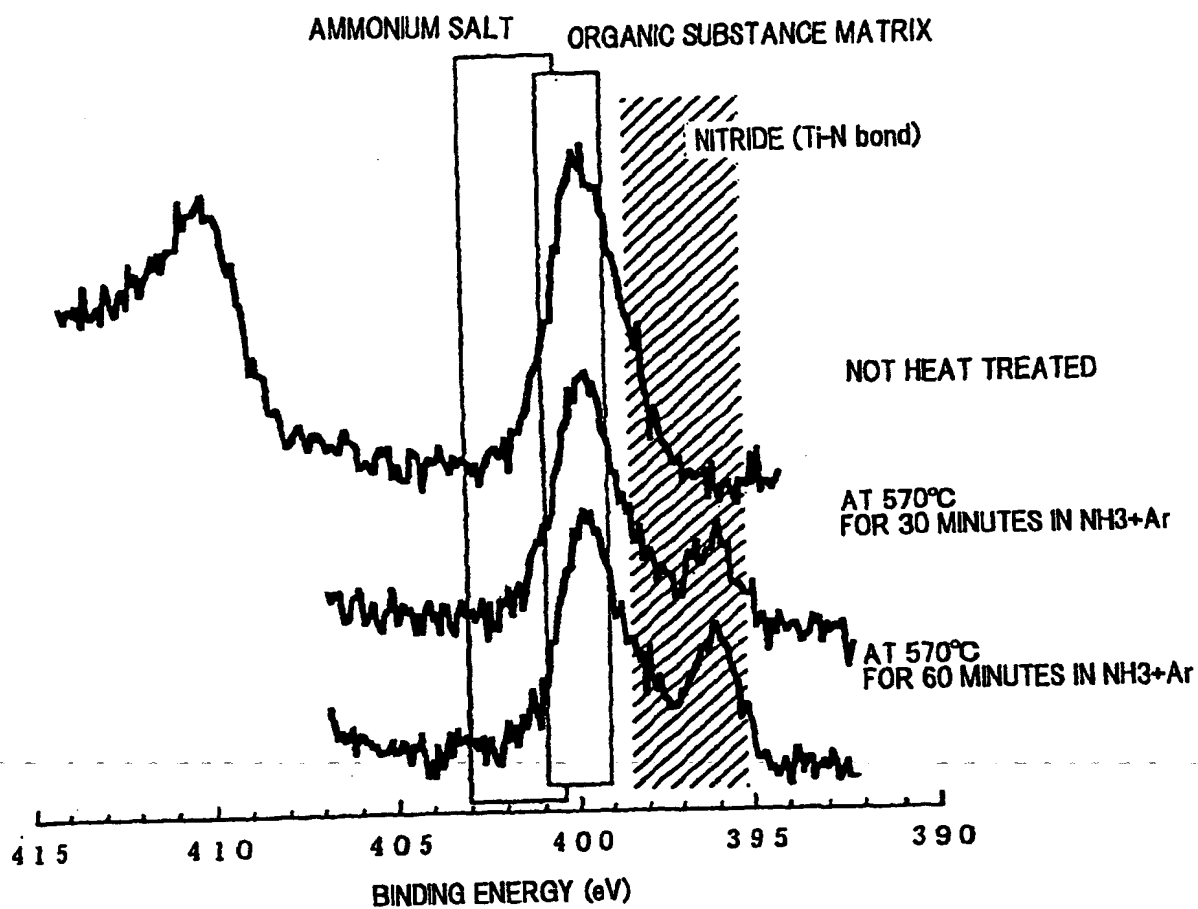


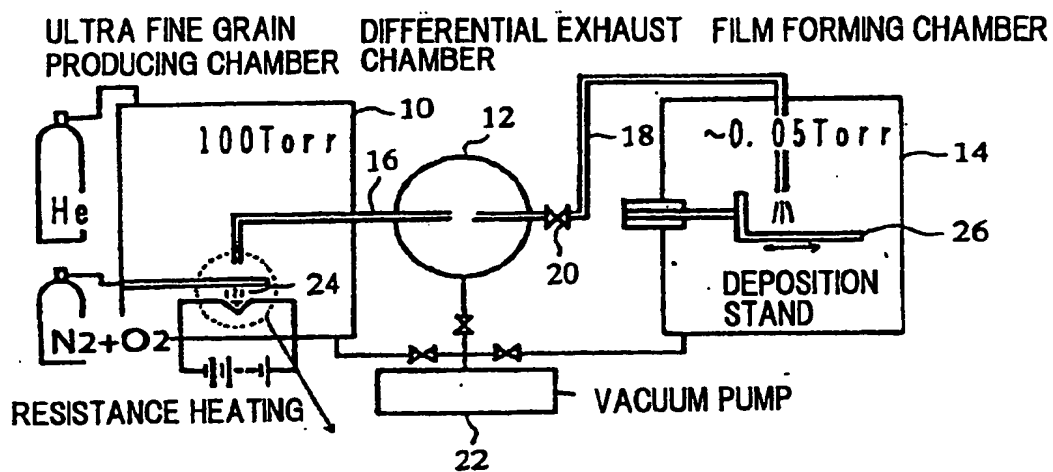
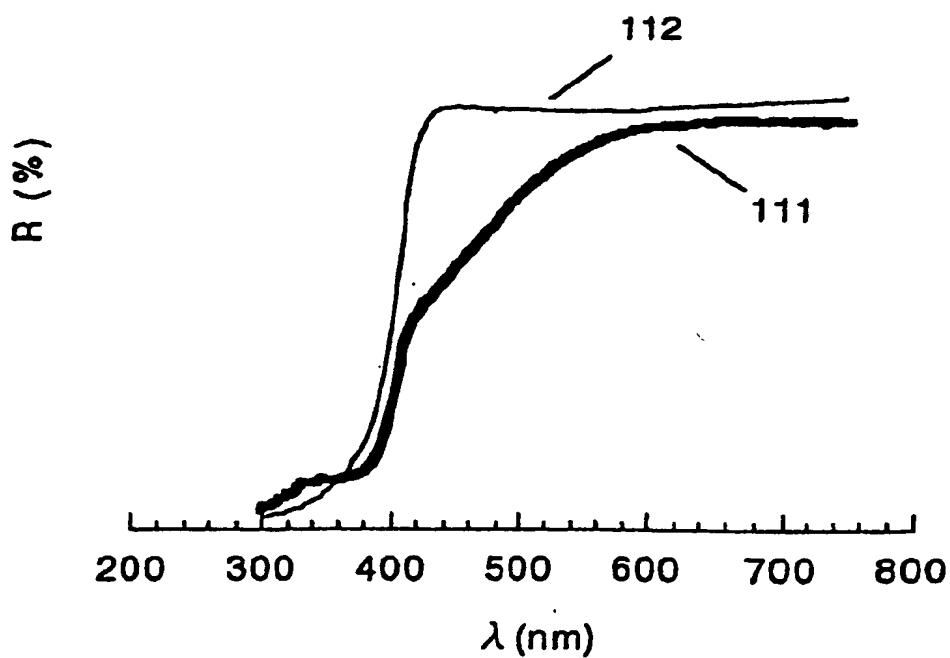
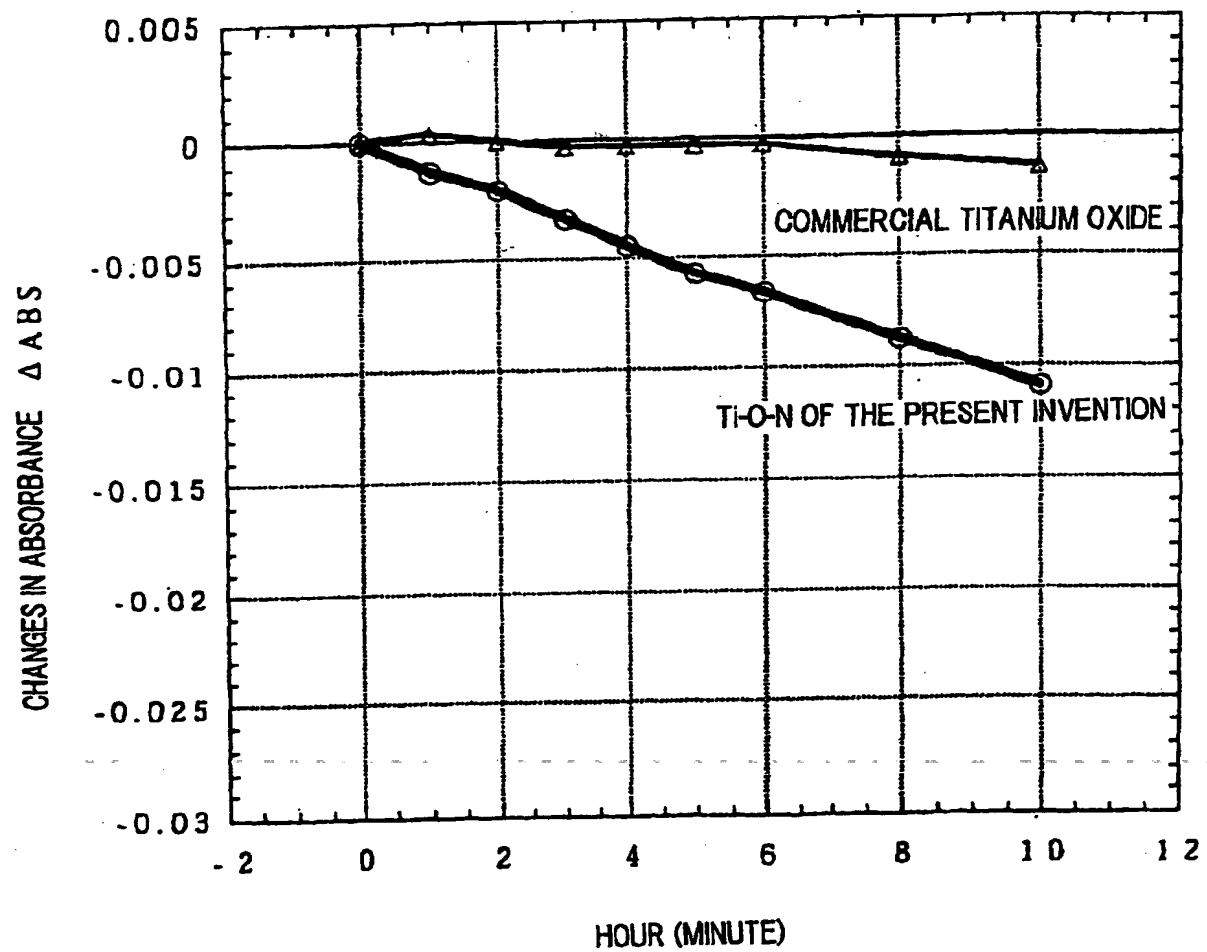
Fig. 17**Fig. 18**

Fig. 19



INTERNATIONAL SEARCH REPORT

International application No.

PCT/JP00/05247

A. CLASSIFICATION OF SUBJECT MATTER
Int.Cl.⁷ B01J35/02

According to International Patent Classification (IPC) or to both national classification and IPC

B. FIELDS SEARCHED

Minimum documentation searched (classification system followed by classification symbols)
Int.Cl.⁷ B01J21/00-37/36Documentation searched other than minimum documentation to the extent that such documents are included in the fields searched
Jitsuyo Shinan Koho 1926-1996 Toroku Jitsuyo Shinan Koho 1994-2000
Kokai Jitsuyo Shinan Koho 1971-2000 Jitsuyo Shinan Toroku Koho 1996-2000Electronic data base consulted during the international search (name of data base and, where practicable, search terms used)
WPI/L
CAS Online

C. DOCUMENTS CONSIDERED TO BE RELEVANT

Category*	Citation of document, with indication, where appropriate, of the relevant passages	Relevant to claim No.
X	JP, 8-134630, A (Agency of Industrial Science and Technology), 28 May, 1996 (28.05.96), Claims; Par. Nos. [0010], [0013], [0021] to [0028] (Family: none)	1-9, 11, 12, 13, 14, 18, 19 10, 15, 16, 17, 20-28
A		
P, X	JP, 2000-140636, A (Sharp Corporation, et al.), 23 May, 2000 (23.05.00), Claims 1 to 5; Par. Nos. [0021] to [0025] (Family: none)	1, 2, 3, 4, 5, 6, 7, 8, 9, 11, 12, 13, 14, 18, 22 10, 15-17, 19-21 , 23-28
P, A		

☐ Further documents are listed in the continuation of Box C.☐ See patent family annex.

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cited to establish the publication date of another citation or other

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"P" document published prior to the international filing date but later

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"X" document of particular relevance; the claimed invention cannot be

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considered to involve an inventive step when the document is

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combination being obvious to a person skilled in the art

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Date of the actual completion of the international search
30 October, 2000 (30.10.00)Date of mailing of the international search report
21 November, 2000 (21.11.00)Name and mailing address of the ISA/
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